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Rhee

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(54) **DISPLAY DEVICE USING SEMICONDUCTOR LIGHT EMITTING DEVICE**

(71) Applicant: **LG Electronics Inc.**, Seoul (KR)

(72) Inventor: **Byungjoon Rhee**, Seoul (KR)

(73) Assignee: **LG ELECTRONICS INC.**, Seoul (KR)

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(30) **Foreign Application Priority Data**

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H01L 25/075 (2006.01)
H01L 33/00 (2010.01)
H01L 33/46 (2010.01)

(52) **U.S. Cl.**

CPC **H01L 25/0753** (2013.01); **H01L 27/156** (2013.01); **H01L 33/0079** (2013.01); **H01L 33/46** (2013.01); **H01L 2224/14** (2013.01)

(58) **Field of Classification Search**

CPC H01L 27/3244; H01L 51/5237; H01L 2251/5315; H01L 51/56; H01L 2924/00; H01L 27/156; H01L 27/3211; H01L 27/3246; H01L 51/5203; H01L 2224/73267; H01L 33/08; H01L 33/24; H01L 33/30; H01L 27/15
USPC 257/89, 88, 98, 432, 40
See application file for complete search history.

(56) **References Cited**

U.S. PATENT DOCUMENTS

2002/0096994 A1* 7/2002 Iwafuchi H01L 21/2007
313/495
2007/0090387 A1* 4/2007 Daniels H01L 24/75
257/99
2010/0267179 A1 10/2010 Miyairi et al.
2013/0092310 A1 4/2013 Ishigami et al.

FOREIGN PATENT DOCUMENTS

JP 2012-084582 A 4/2012
JP 2012-186322 A 9/2012
KR 10-2010-0038937 A 4/2010
KR 10-2012-0038539 A 4/2012
KR 10-2014-0101602 A 8/2014

* cited by examiner

Primary Examiner — Chuong A Luu

Assistant Examiner — Rodolfo Fortich

(74) *Attorney, Agent, or Firm* — Birch, Stewart, Kolasch & Birch, LLP

(57) **ABSTRACT**

A display device according to an embodiment of the present disclosure may include a lower substrate disposed with a line electrode at an upper portion thereof, a plurality of semiconductor light emitting devices electrically connected to the line electrode to generate light and disposed to be separated from one another, and an adhesive portion including a body configured to fix the location of the lower substrate to that of the semiconductor light emitting device, and a conductor dispersed within the body to electrically connect the lower substrate to the semiconductor light emitting device, wherein the plurality of semiconductor light emitting devices form one pixel region (P) having red, green and blue semiconductor light emitting devices that emit red, green and blue light, and contain a material selected from inorganic semiconductor materials, and the adhesive portion blocks light generated from the plurality of semiconductor light emitting devices.

19 Claims, 13 Drawing Sheets

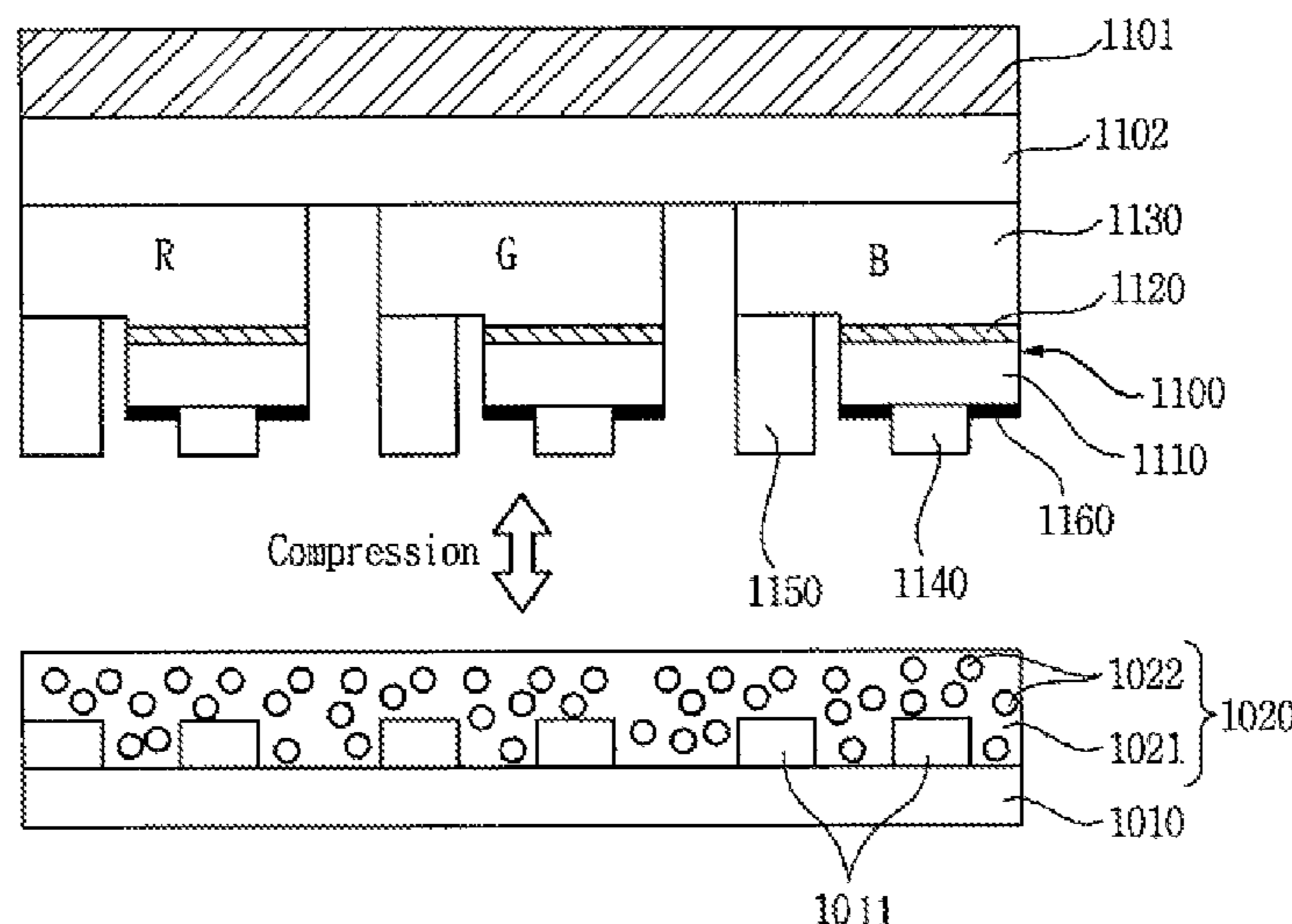


FIG. 1

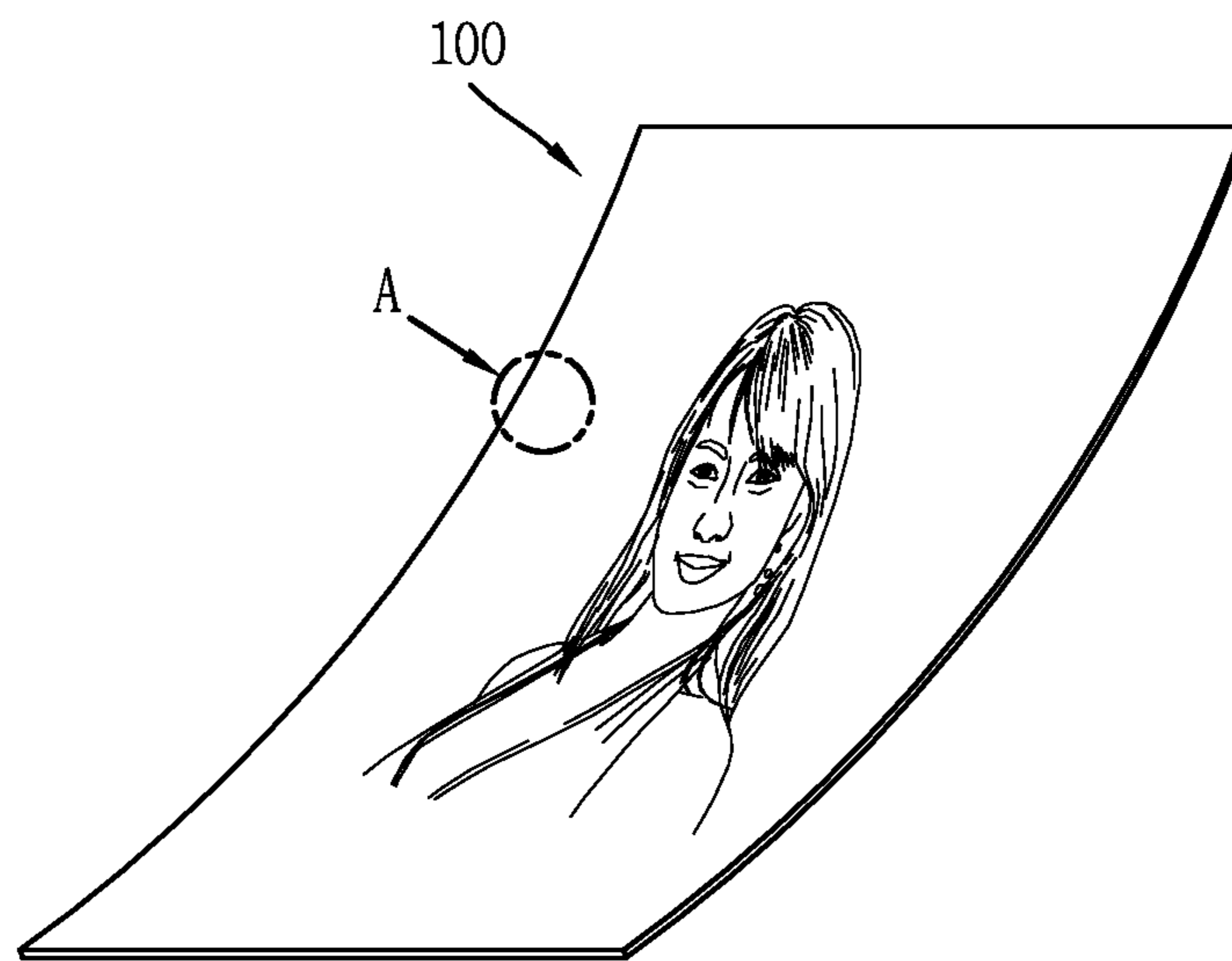


FIG. 2

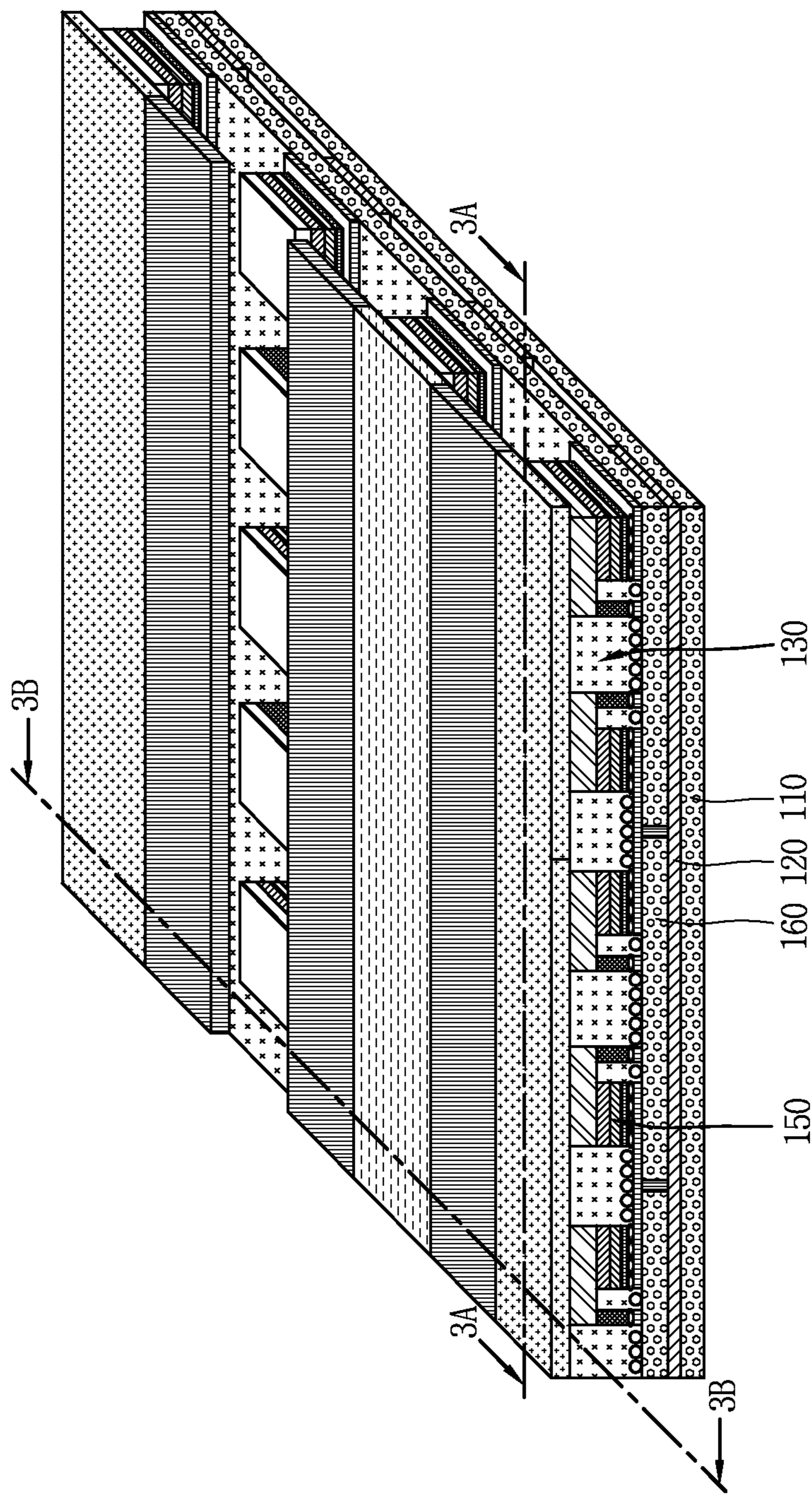


FIG. 3A

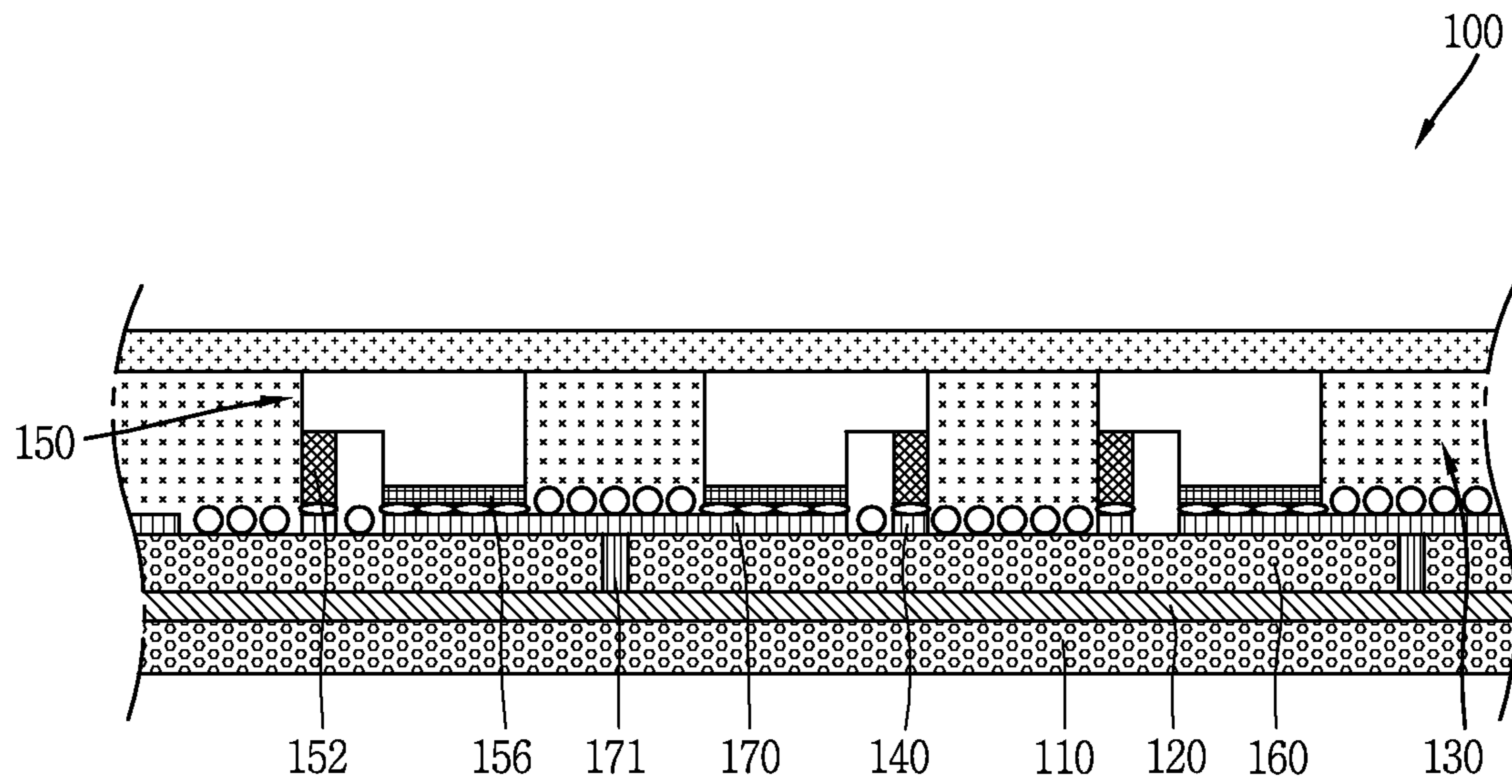


FIG. 3B

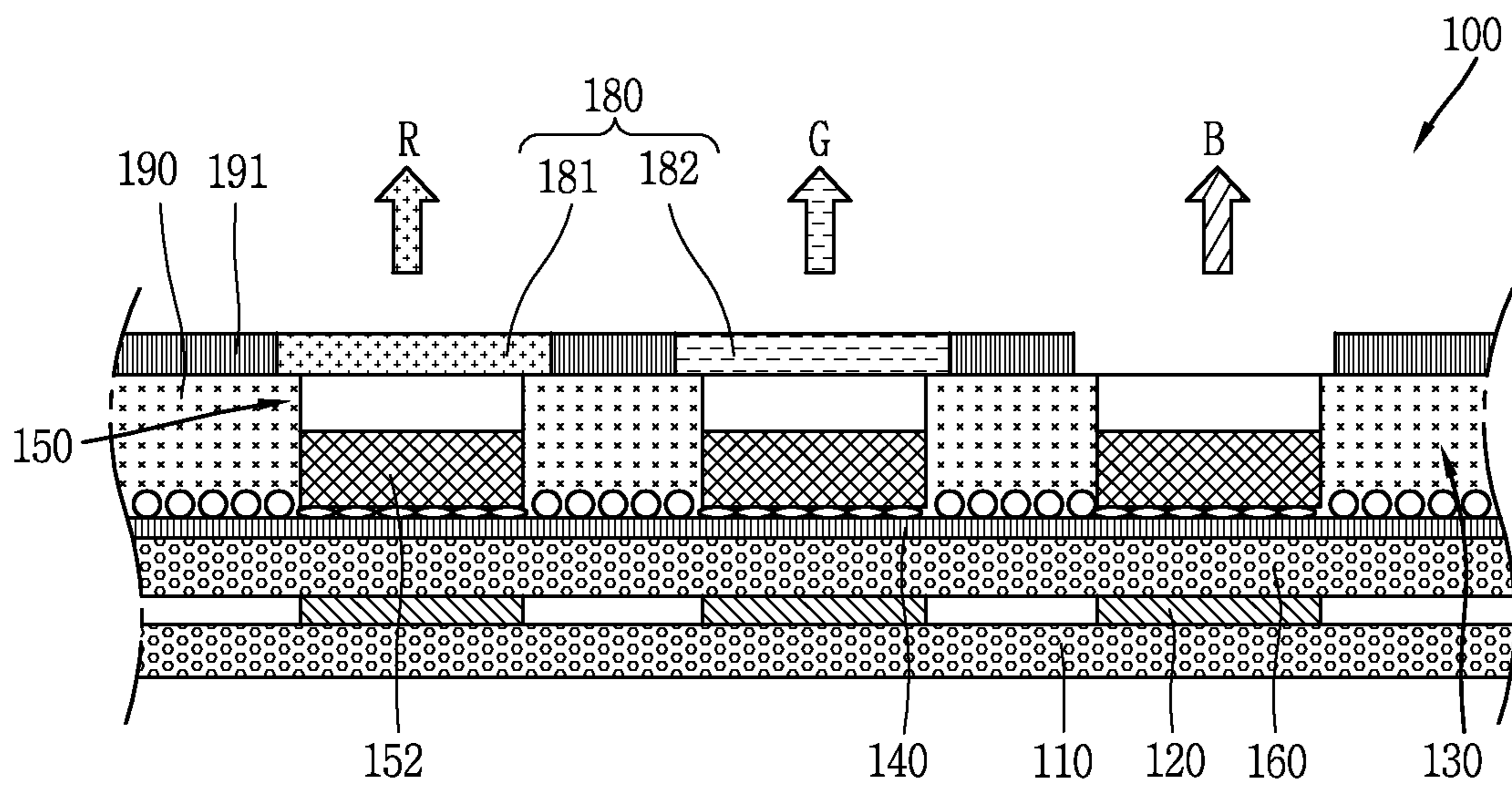


FIG. 4

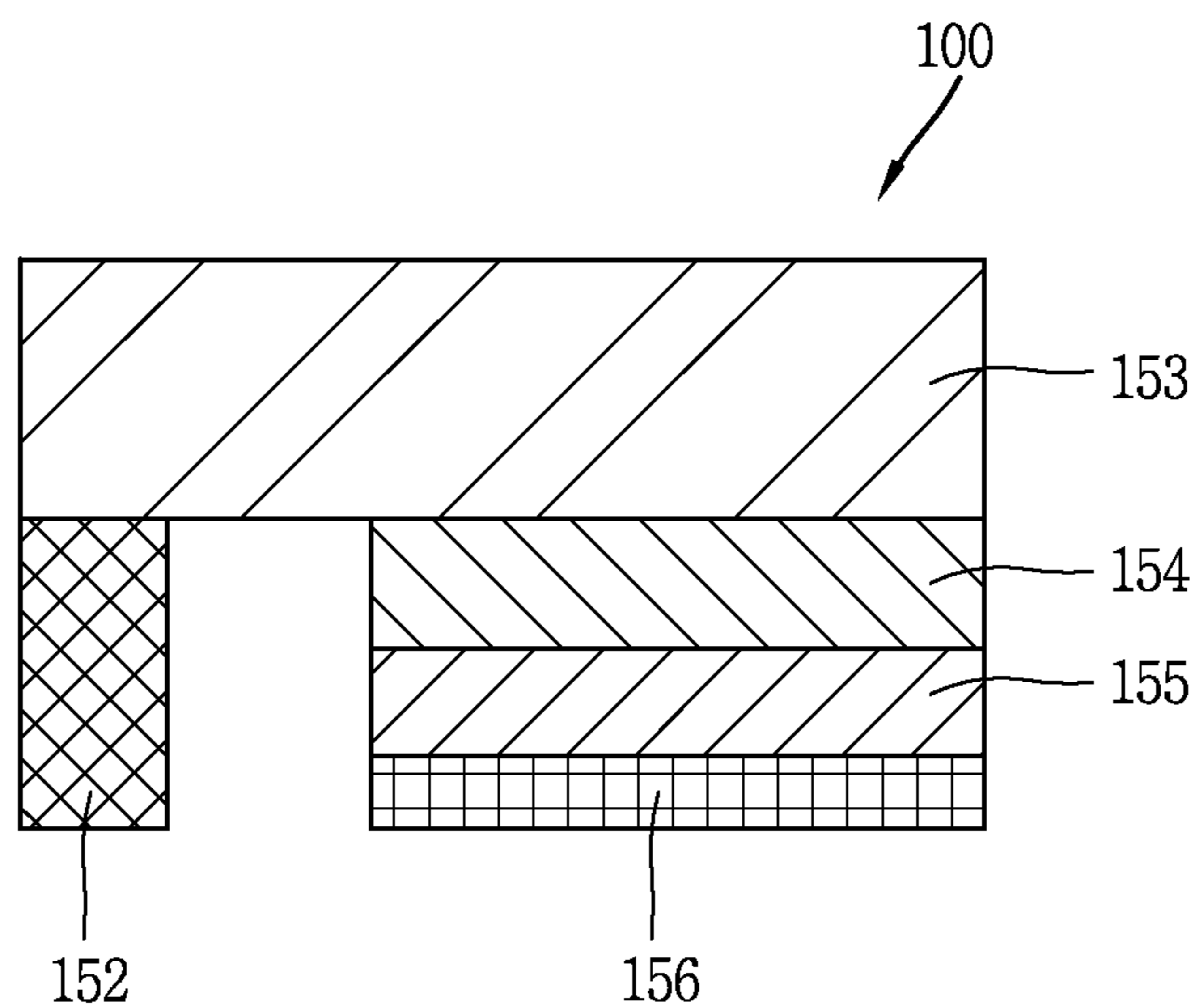


FIG. 5A

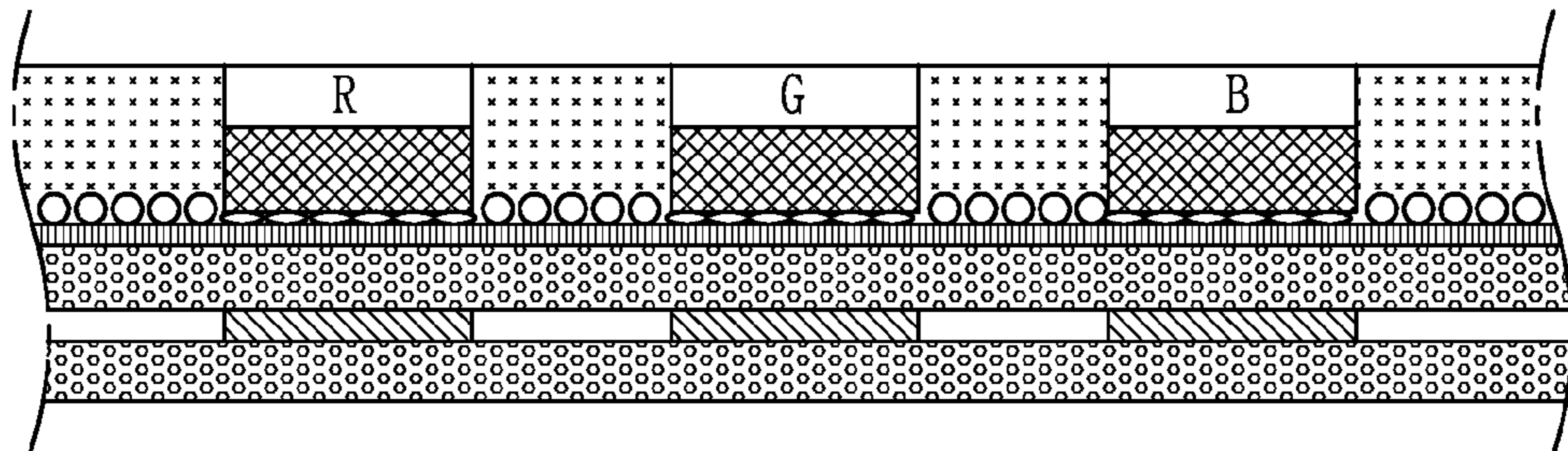


FIG. 5B

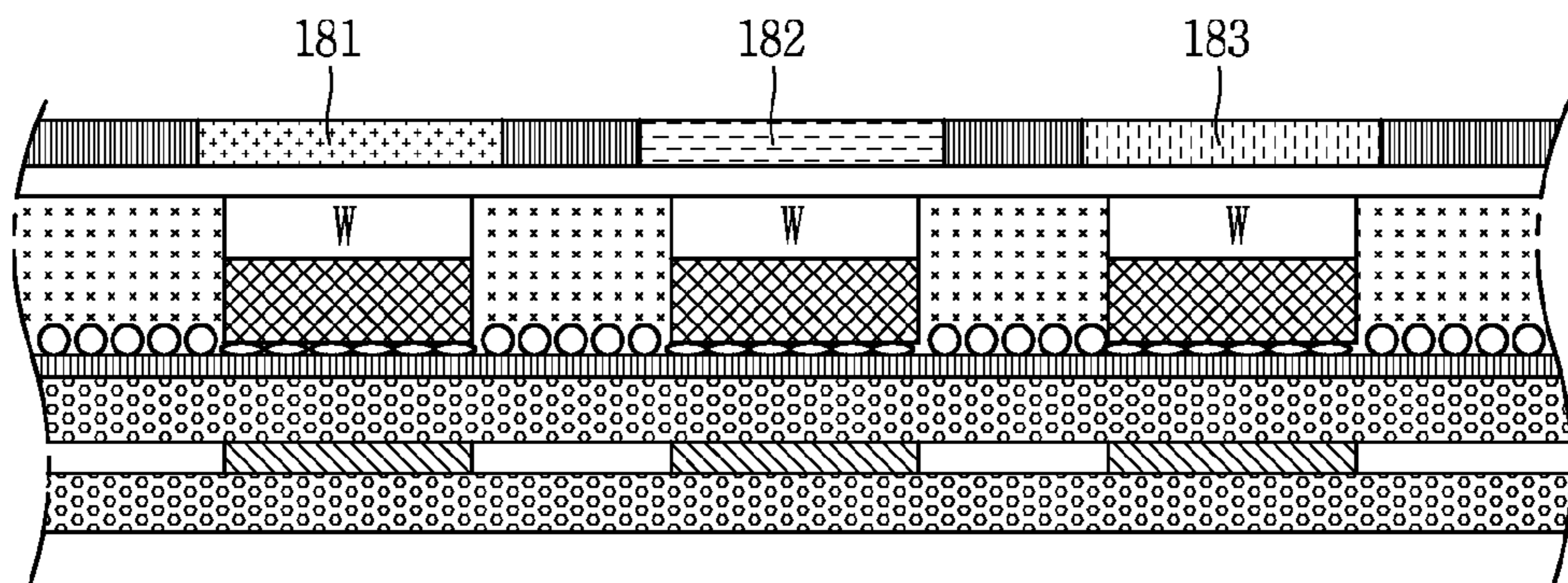


FIG. 5C

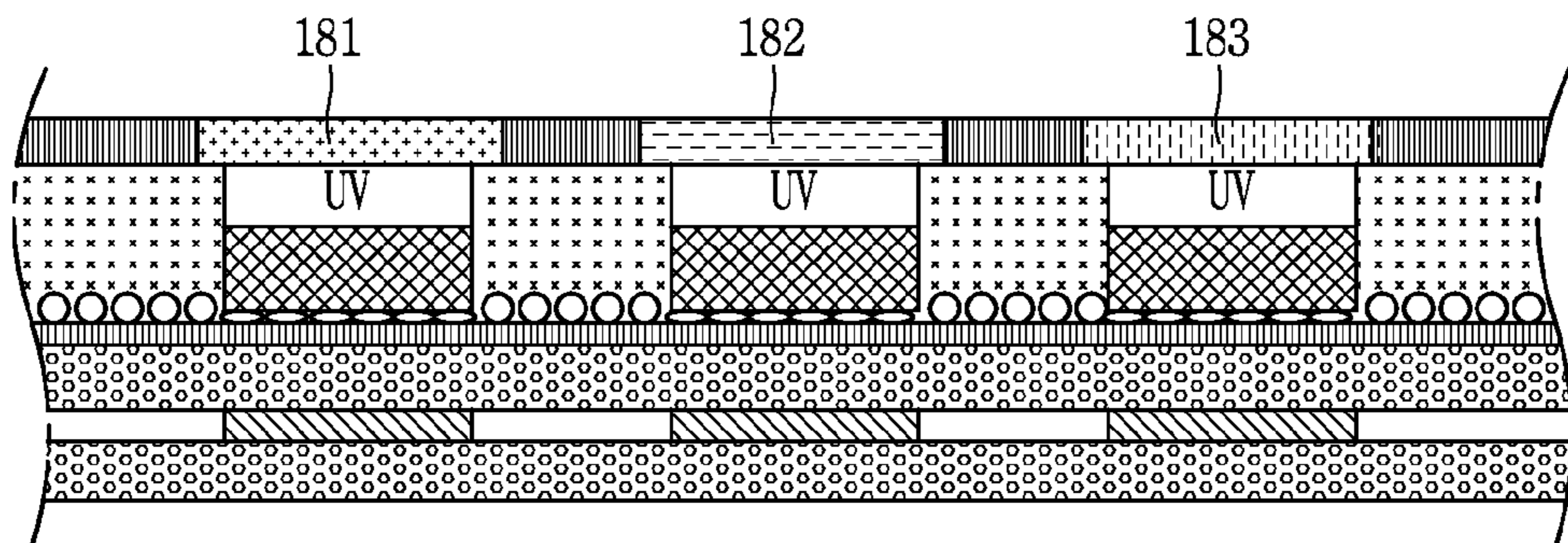


FIG. 6

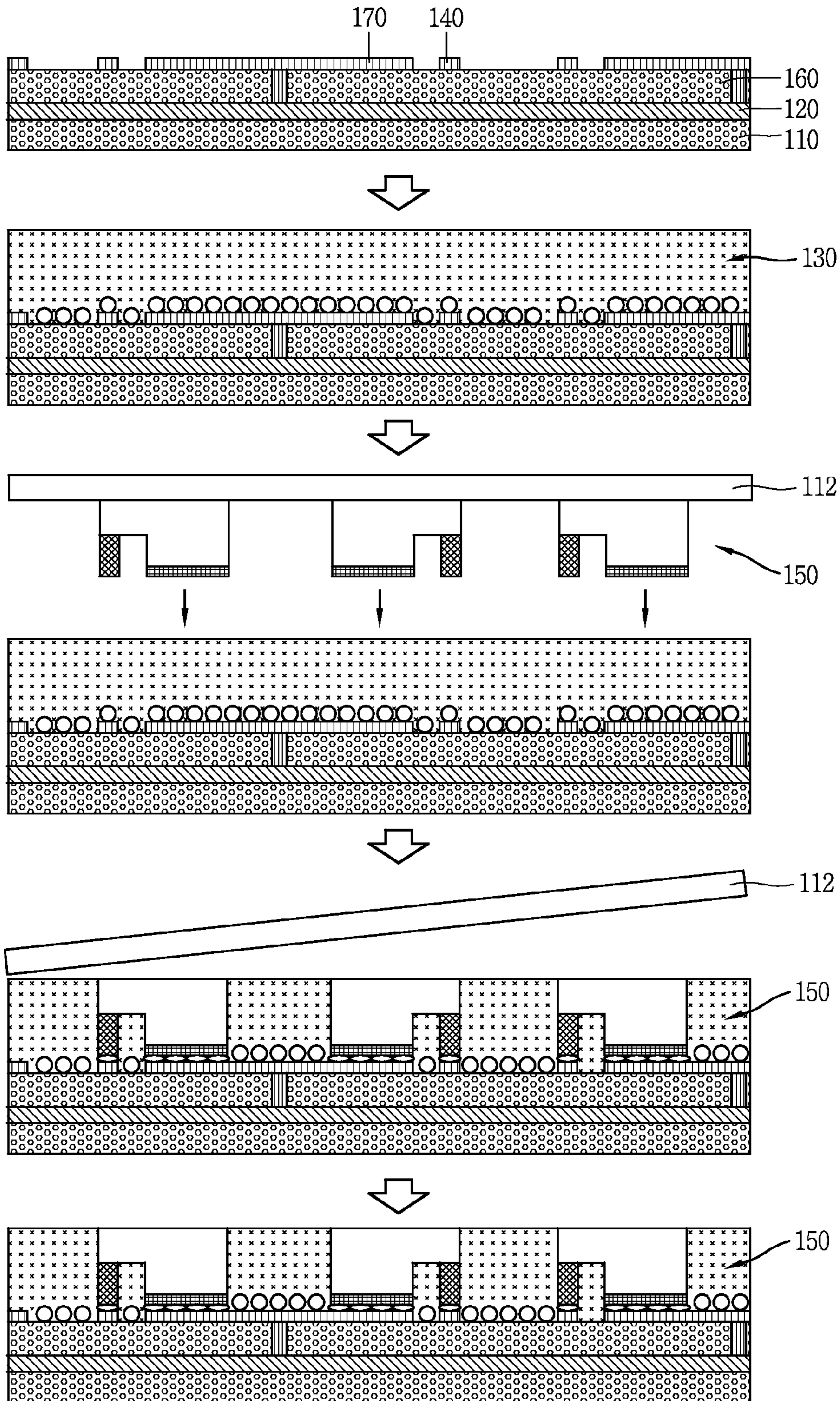


FIG. 7

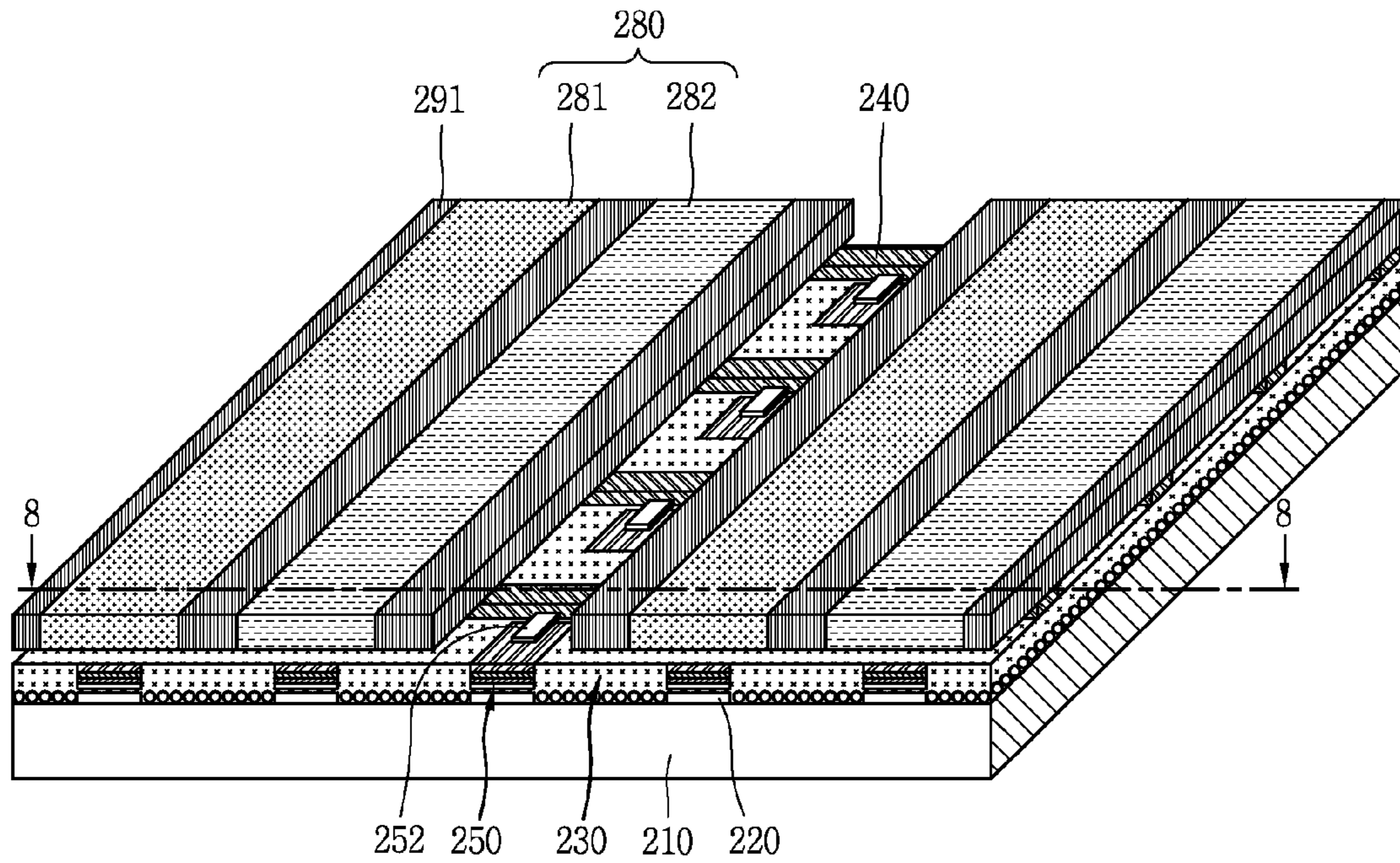


FIG. 8

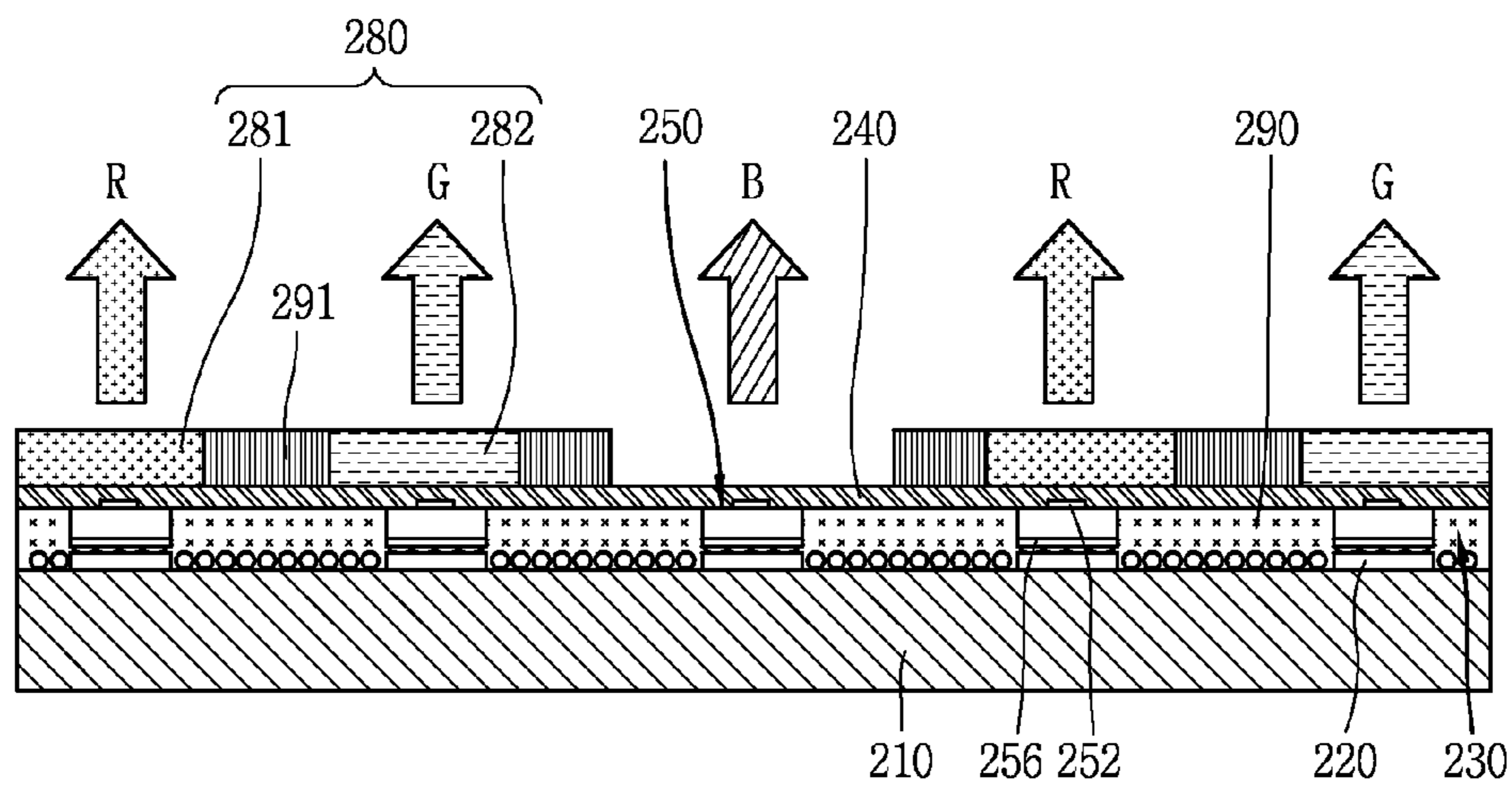


FIG. 9

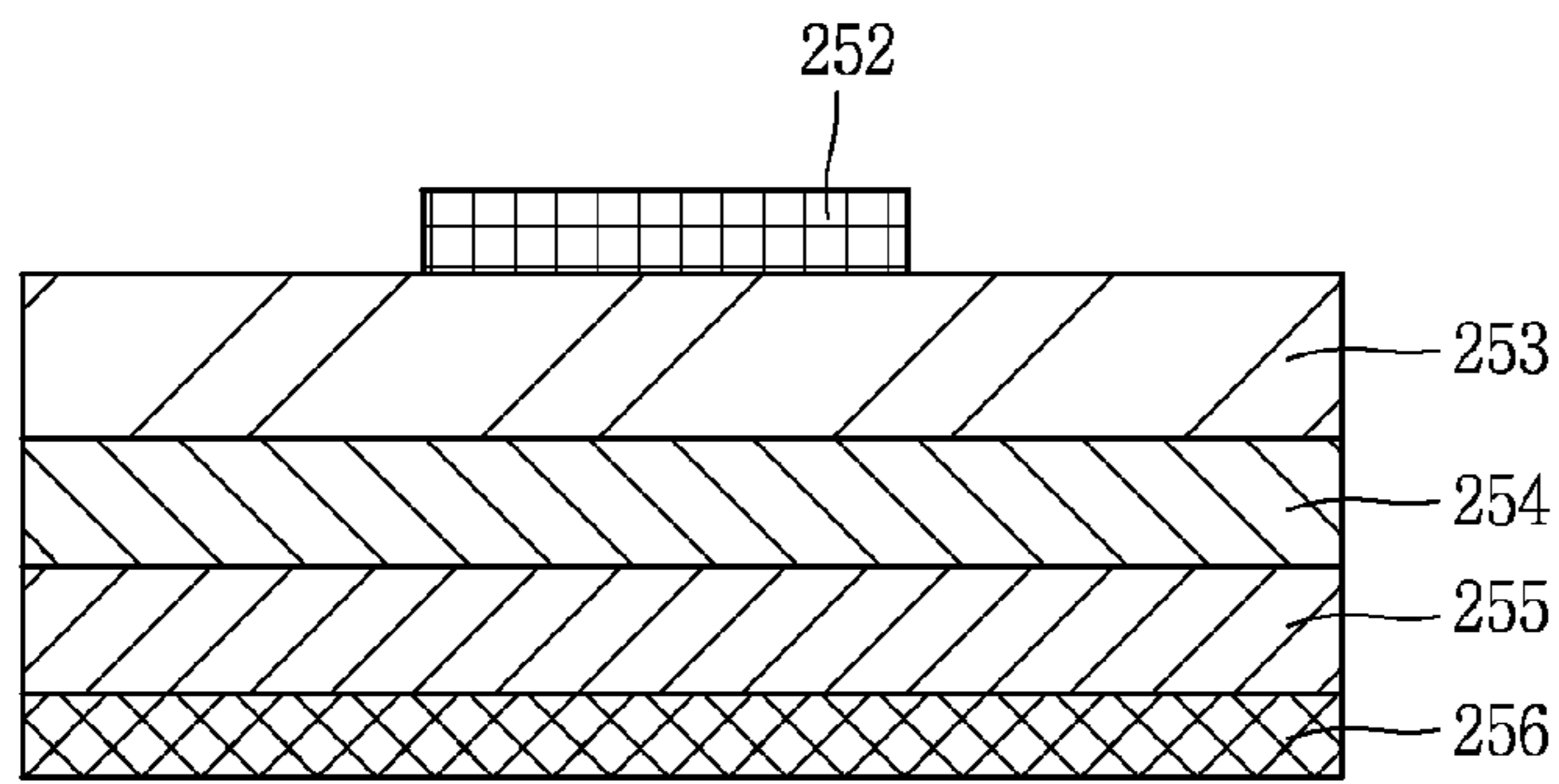


FIG. 10

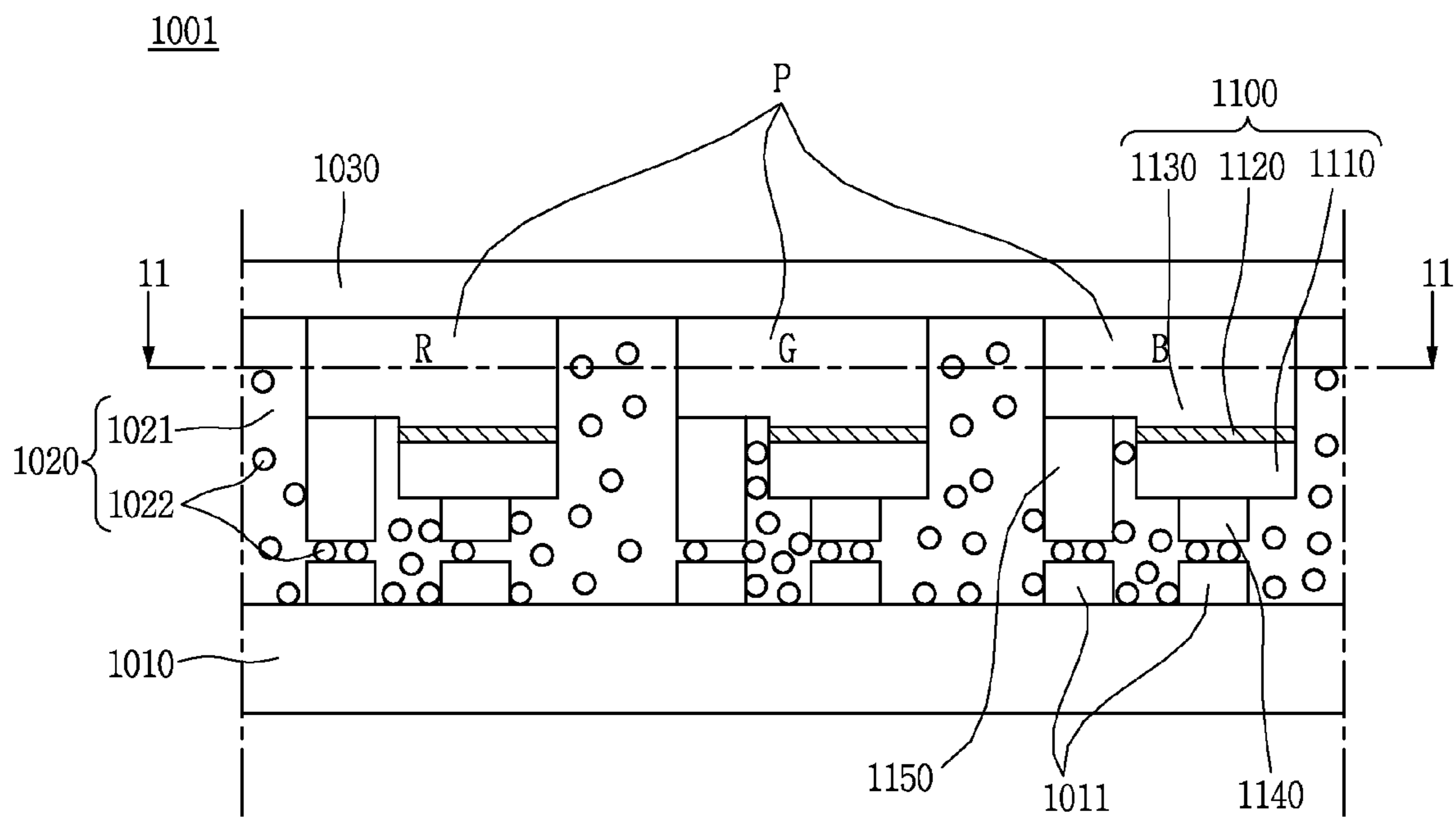


FIG. 11

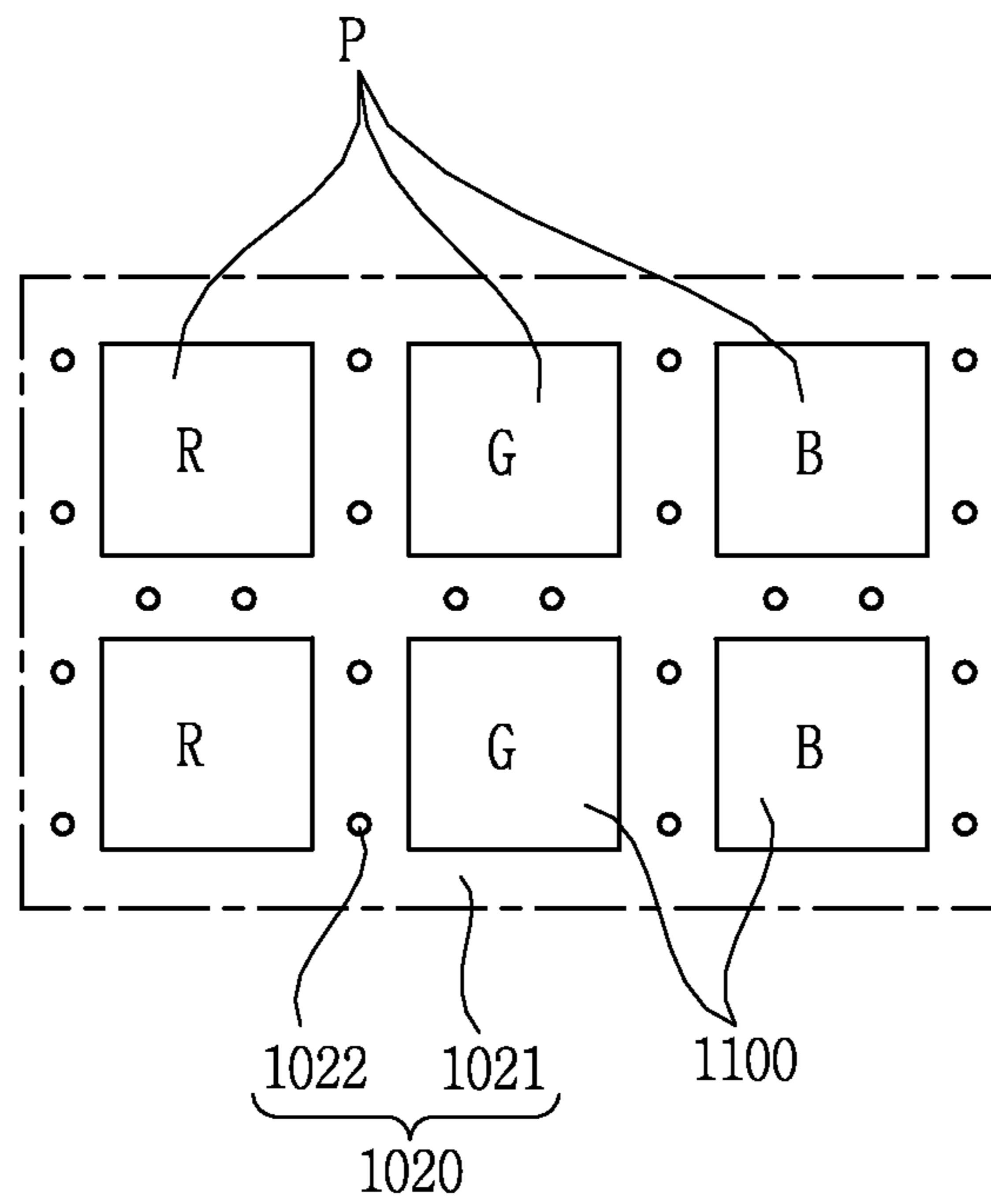


FIG. 12

1100

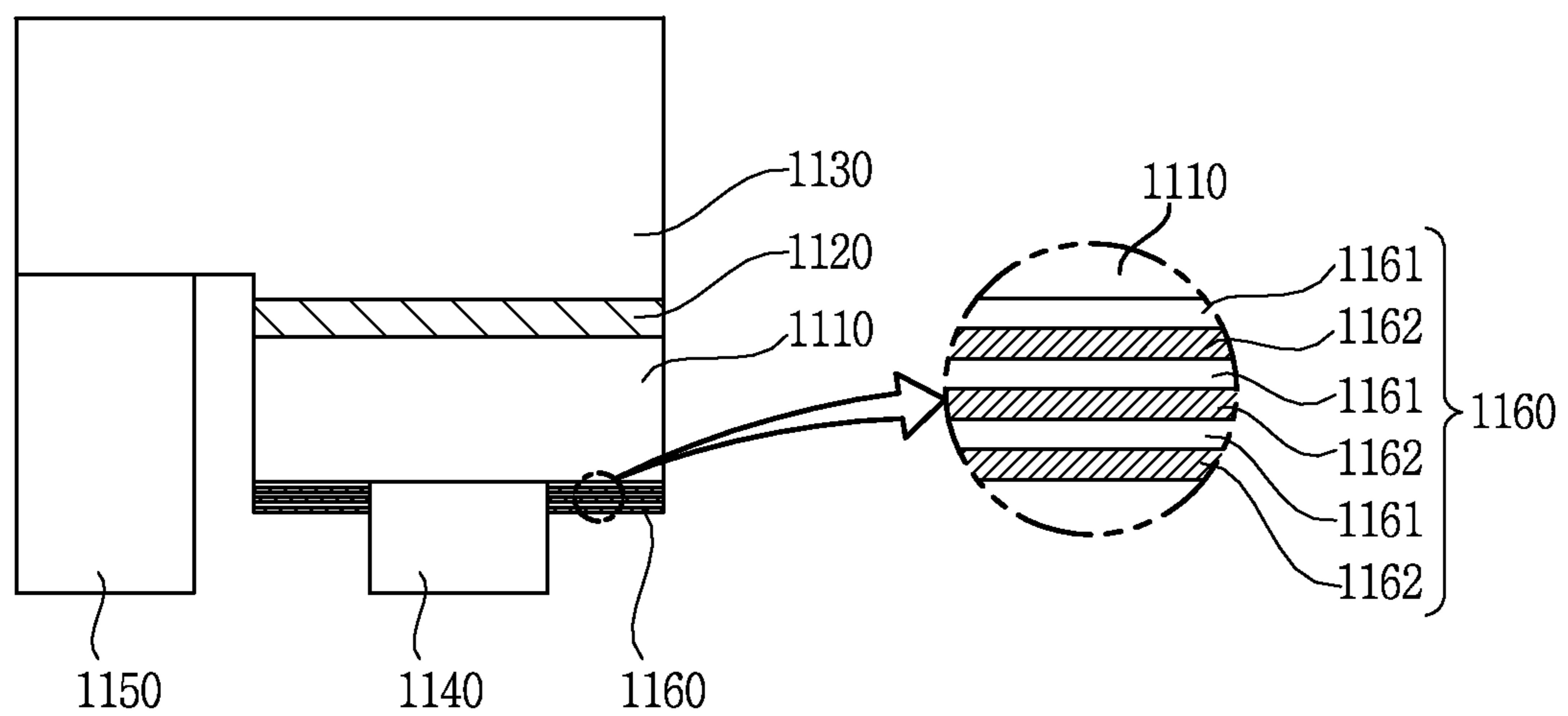


FIG. 13

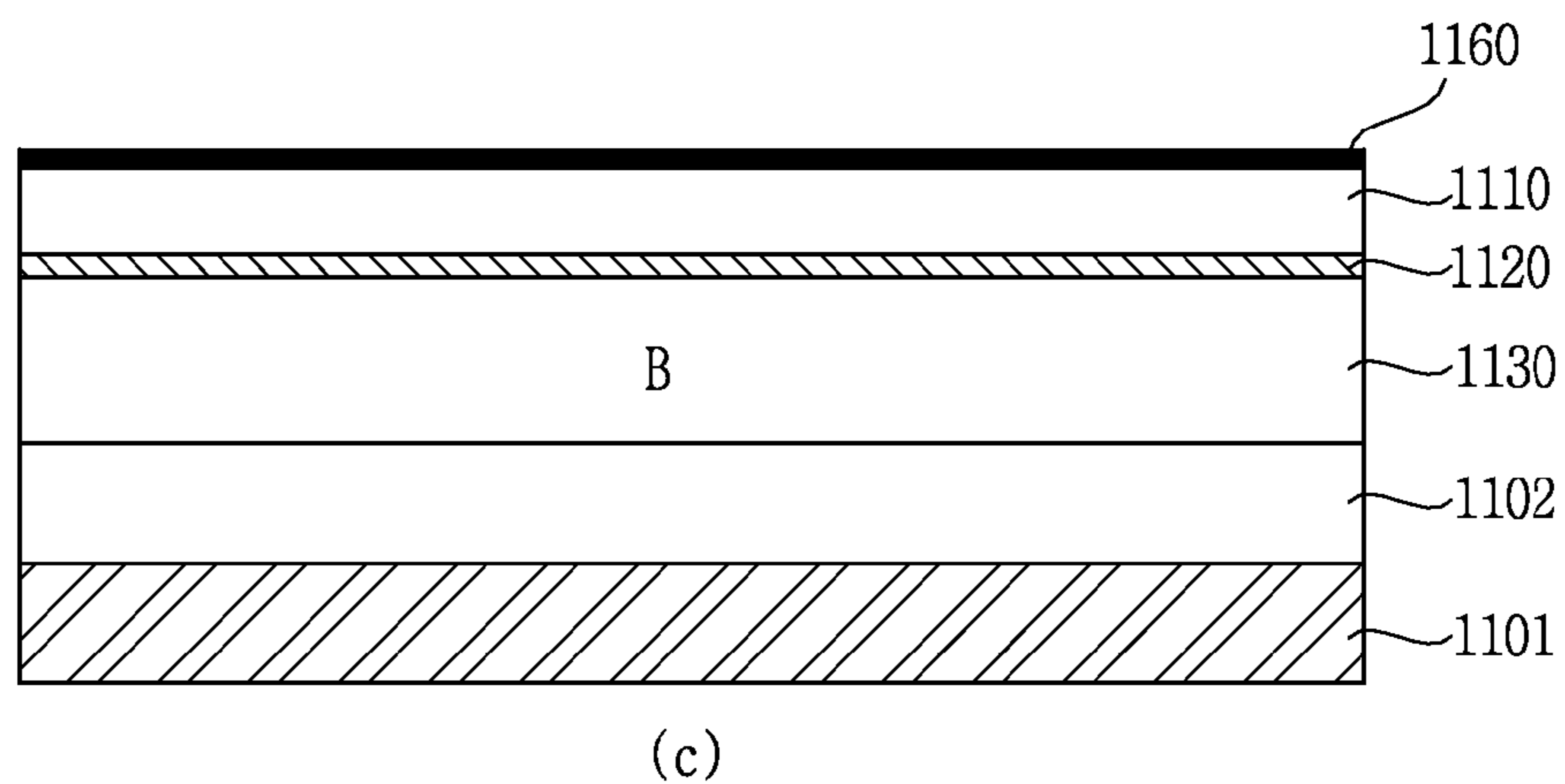
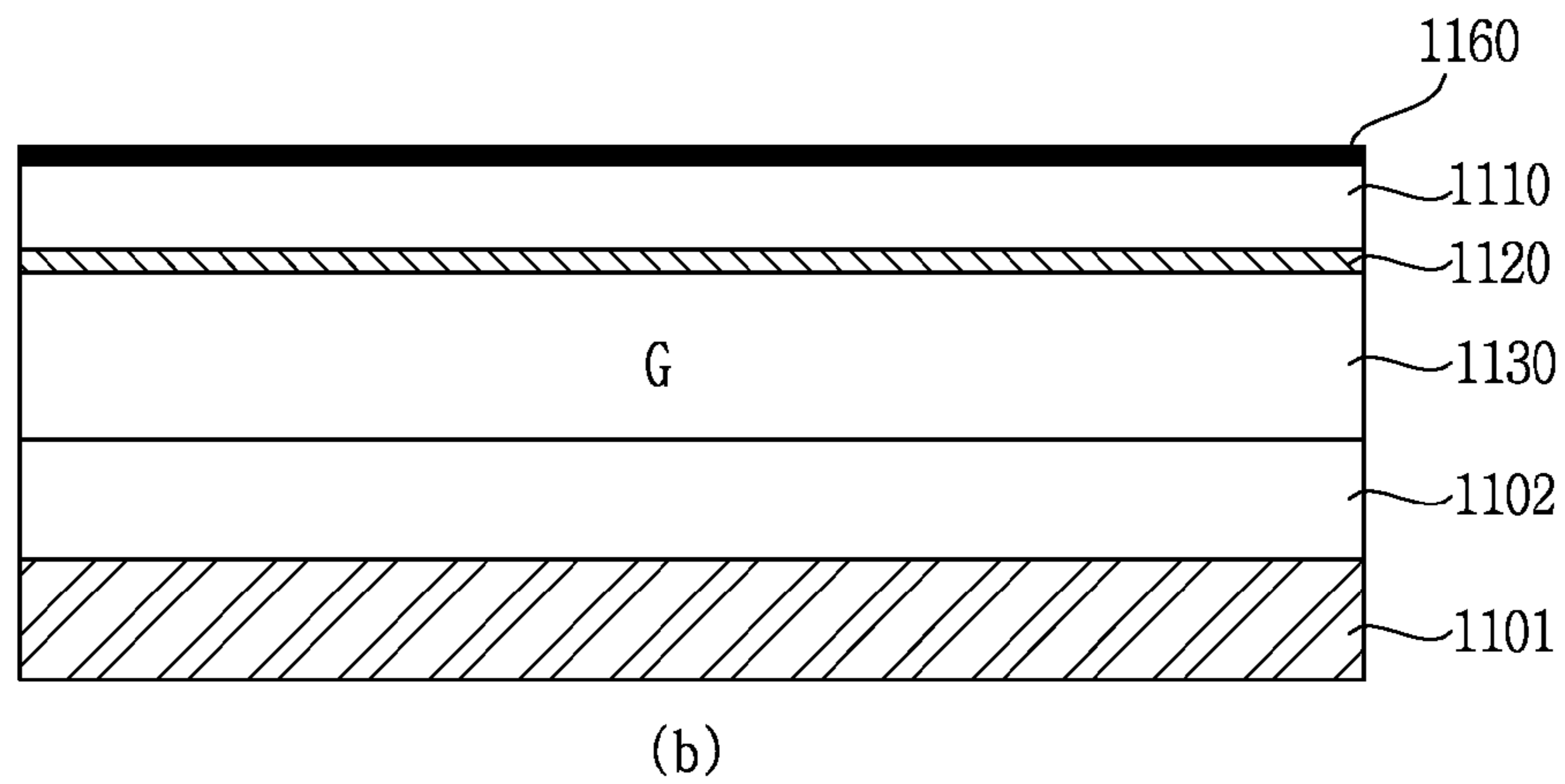
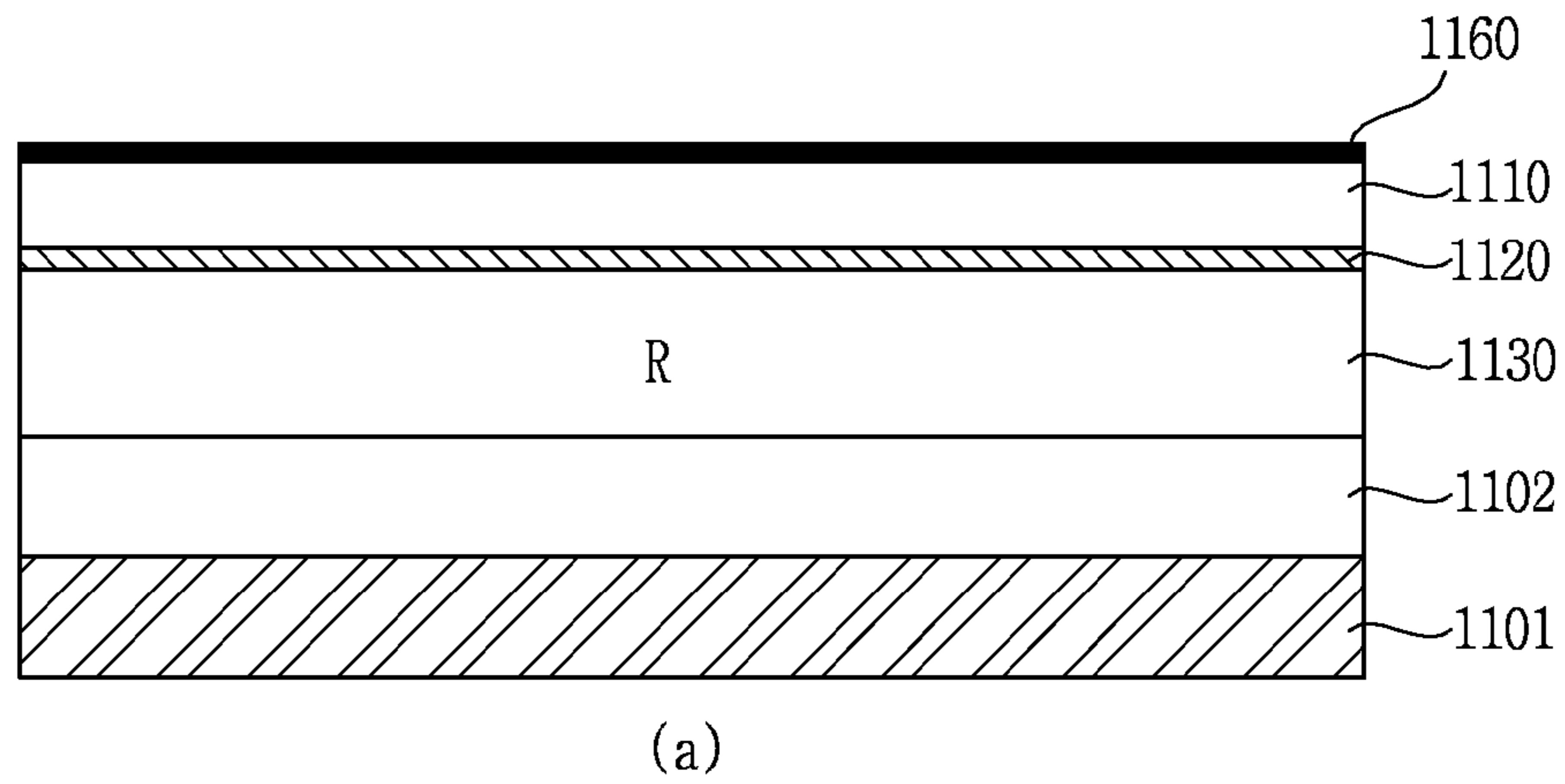
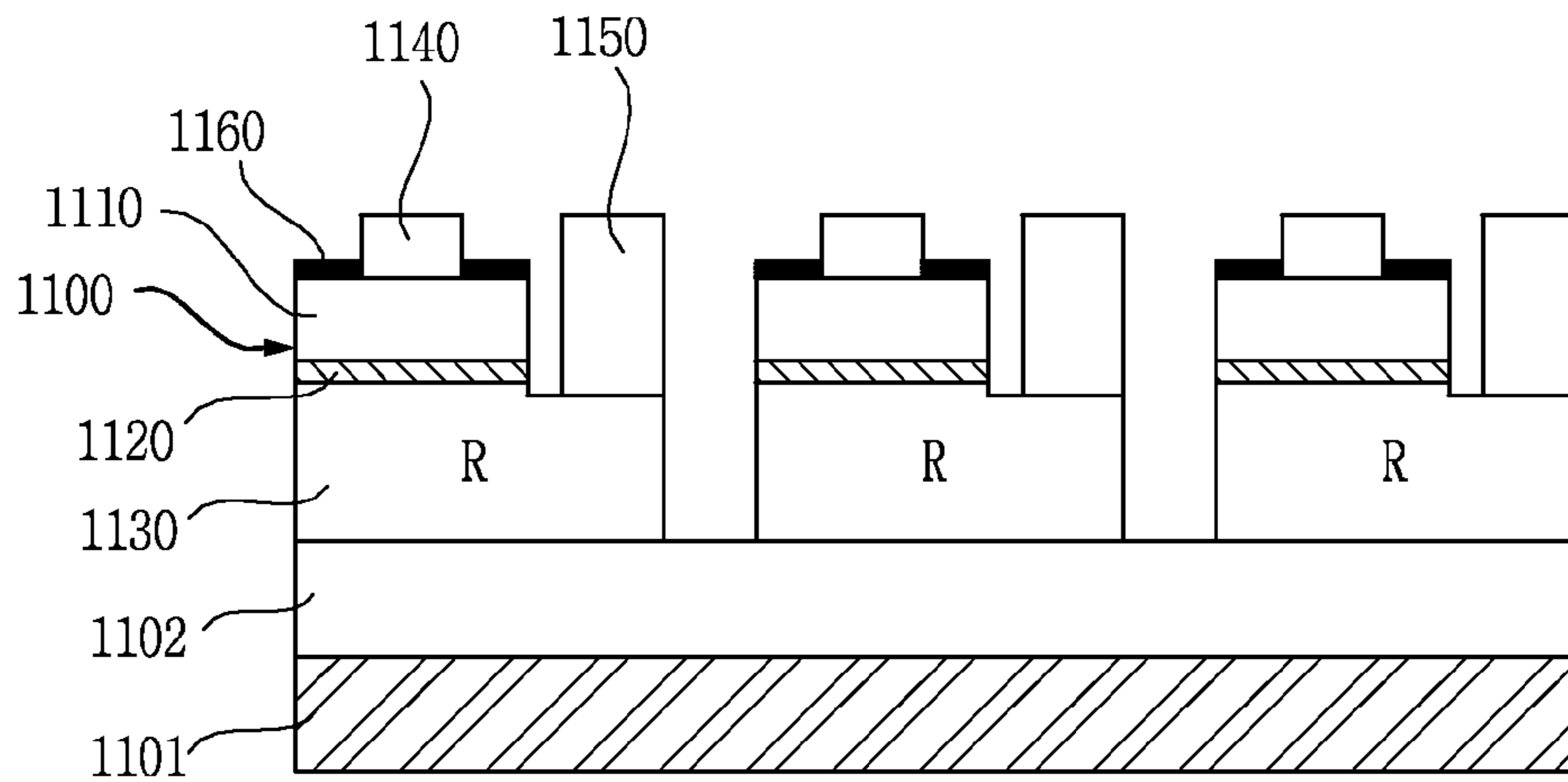
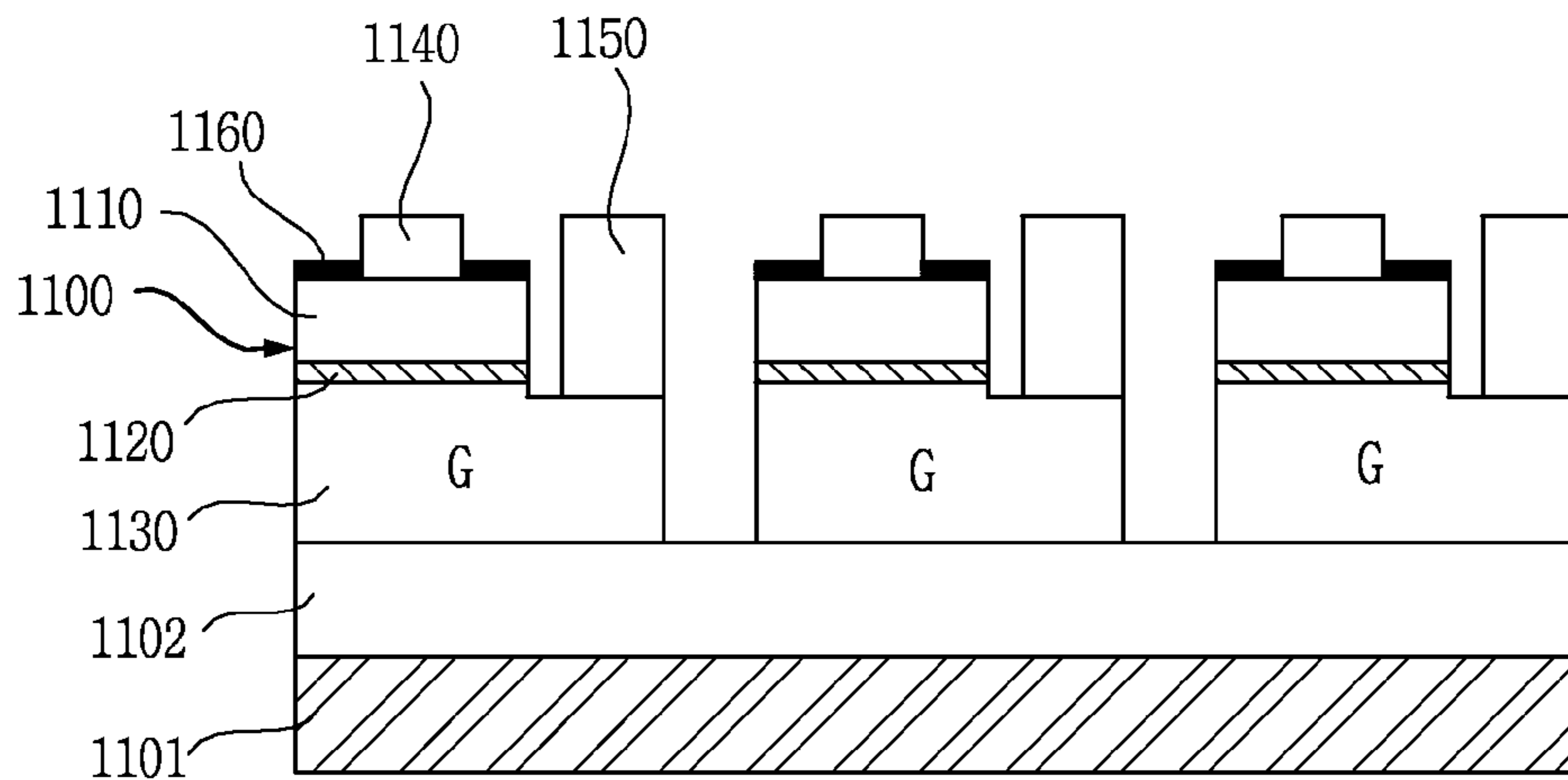


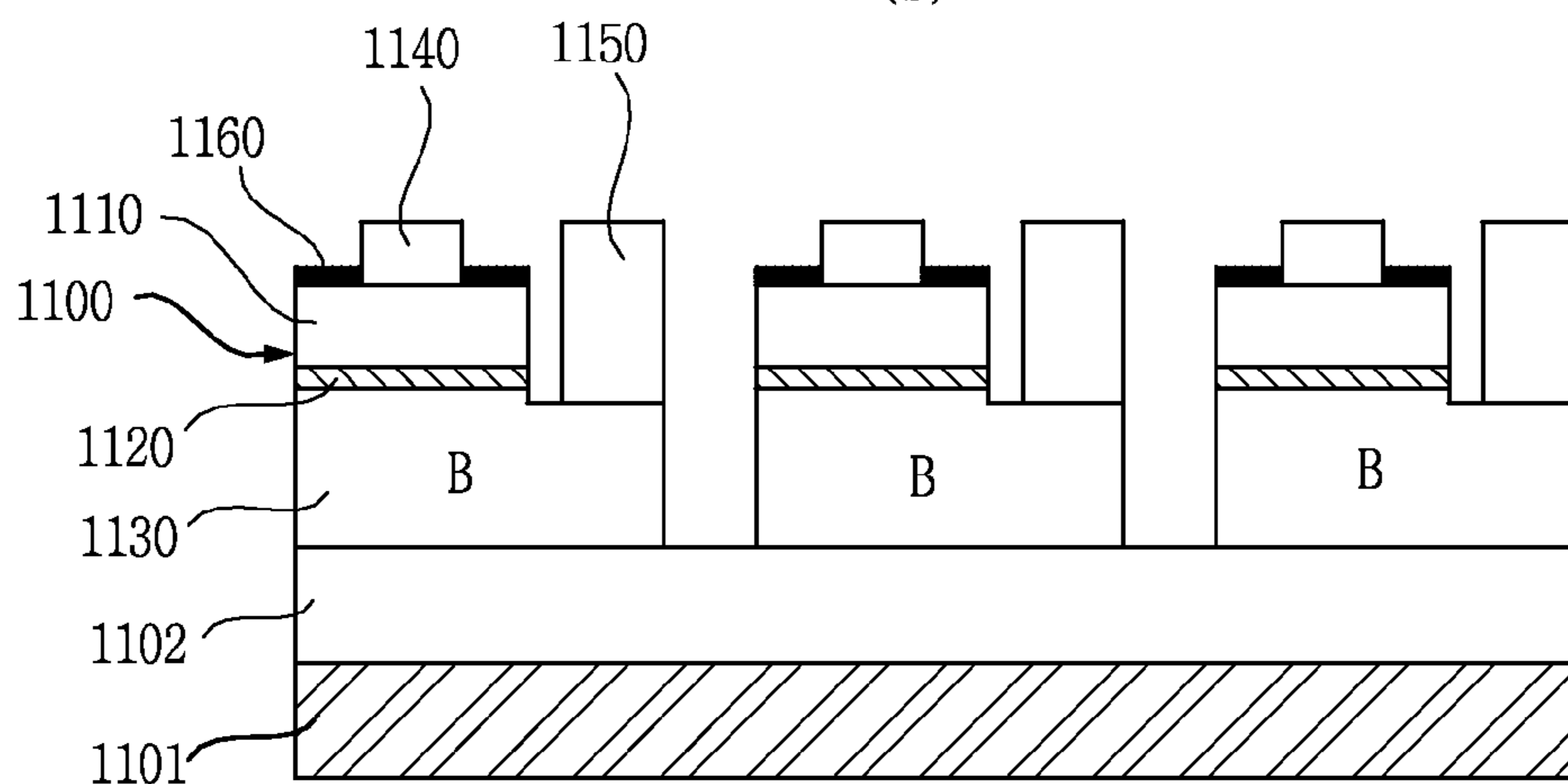
FIG. 14



(a)



(b)



(c)

FIG. 15

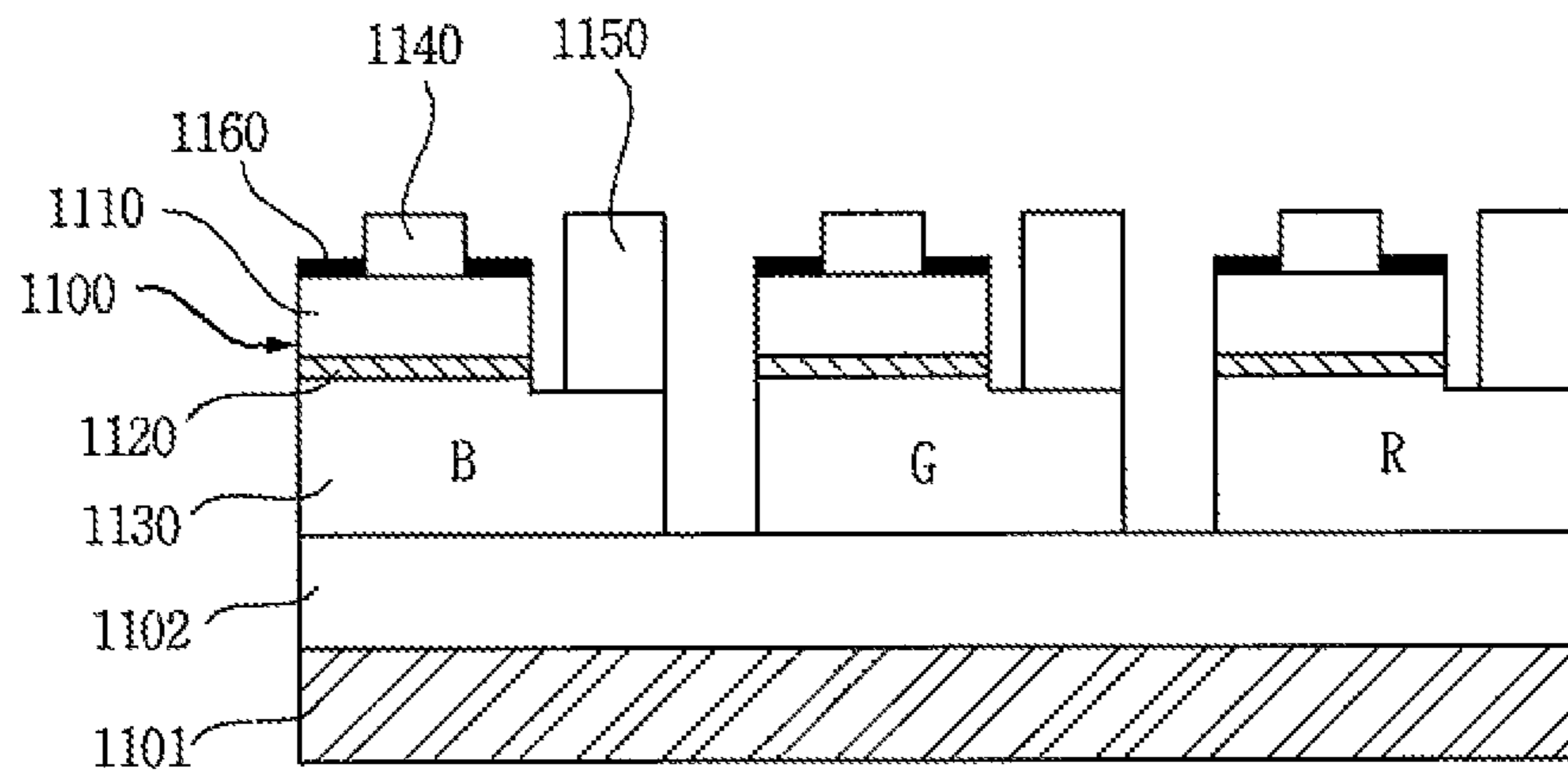


FIG. 16

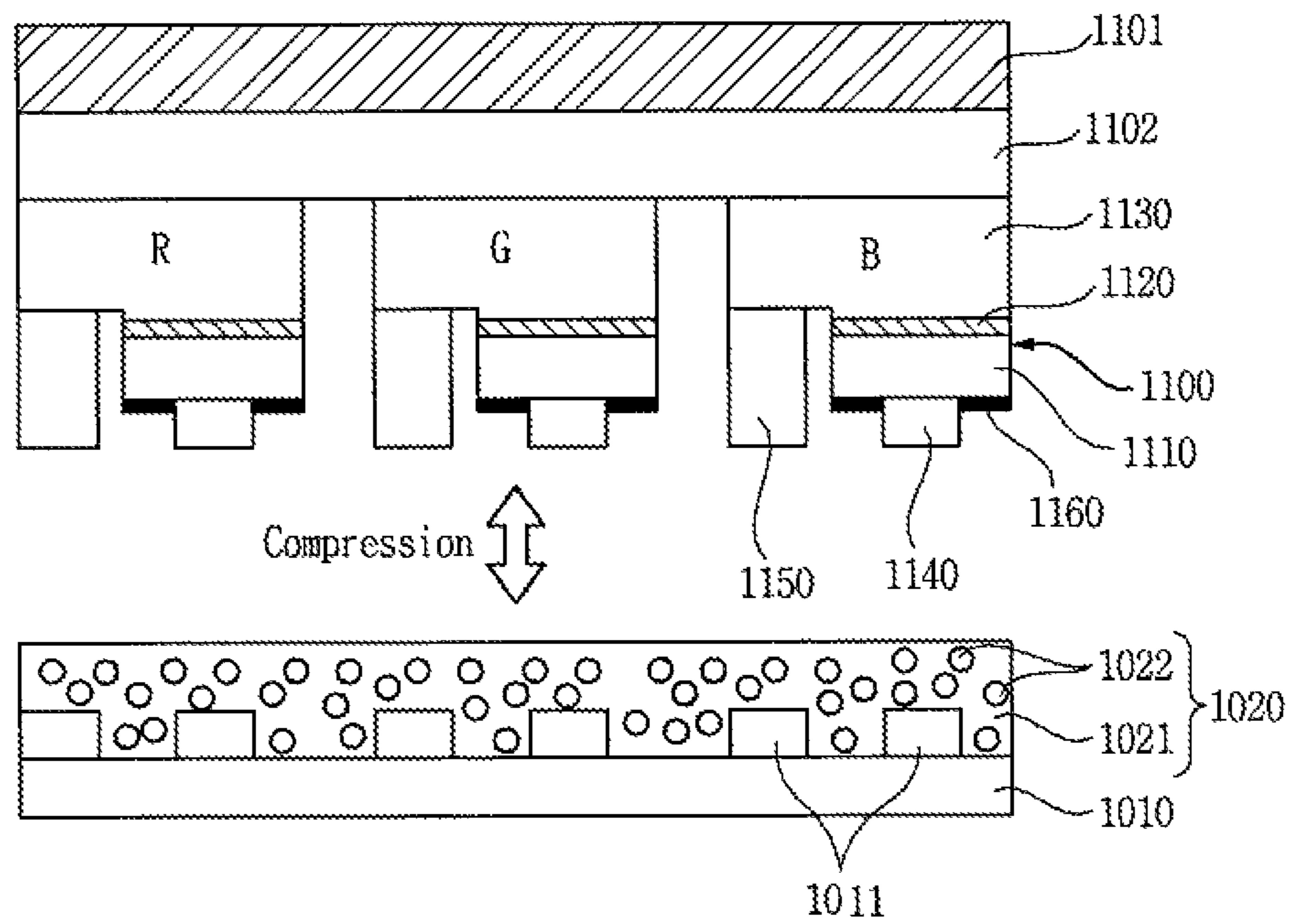


FIG. 17

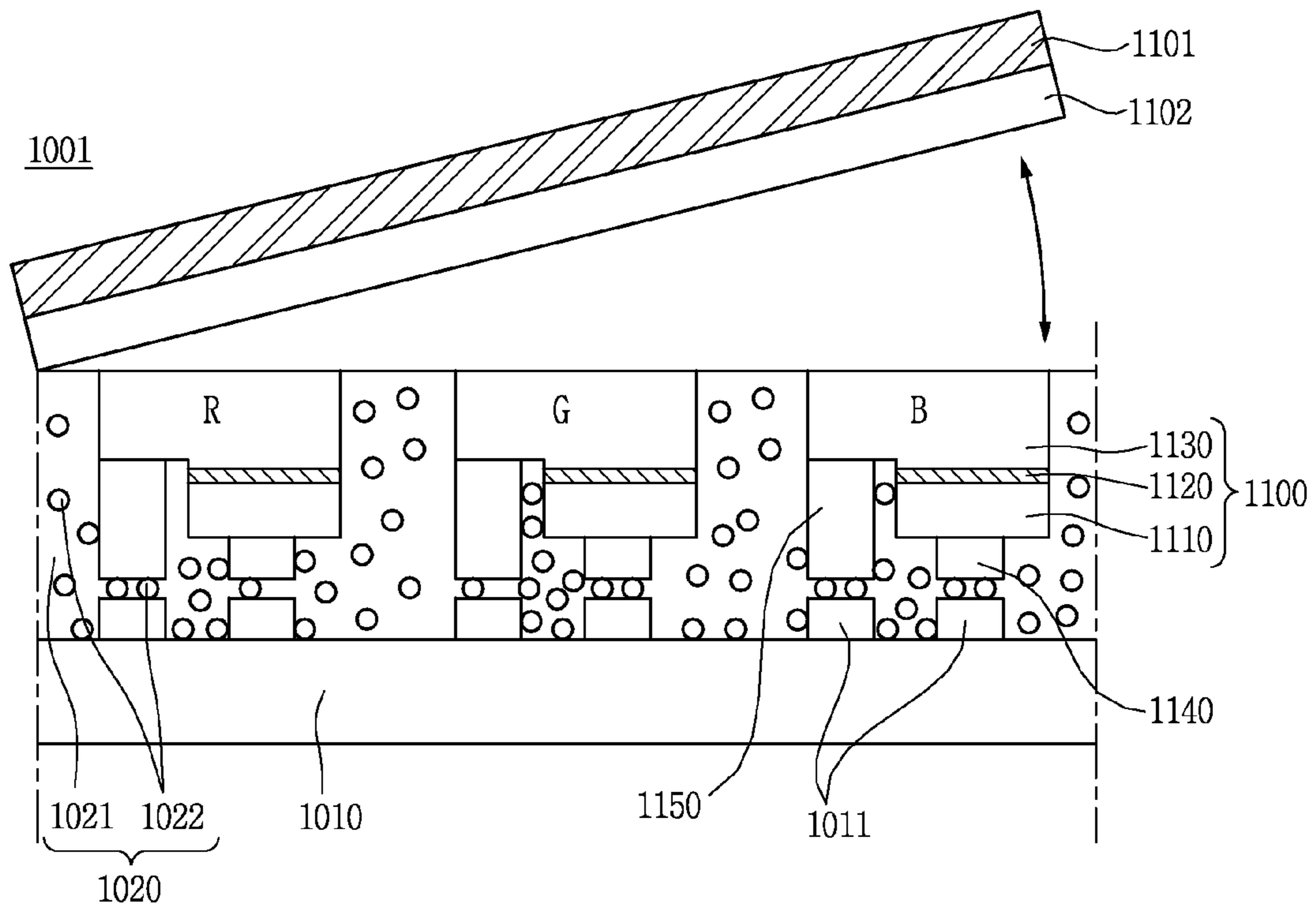
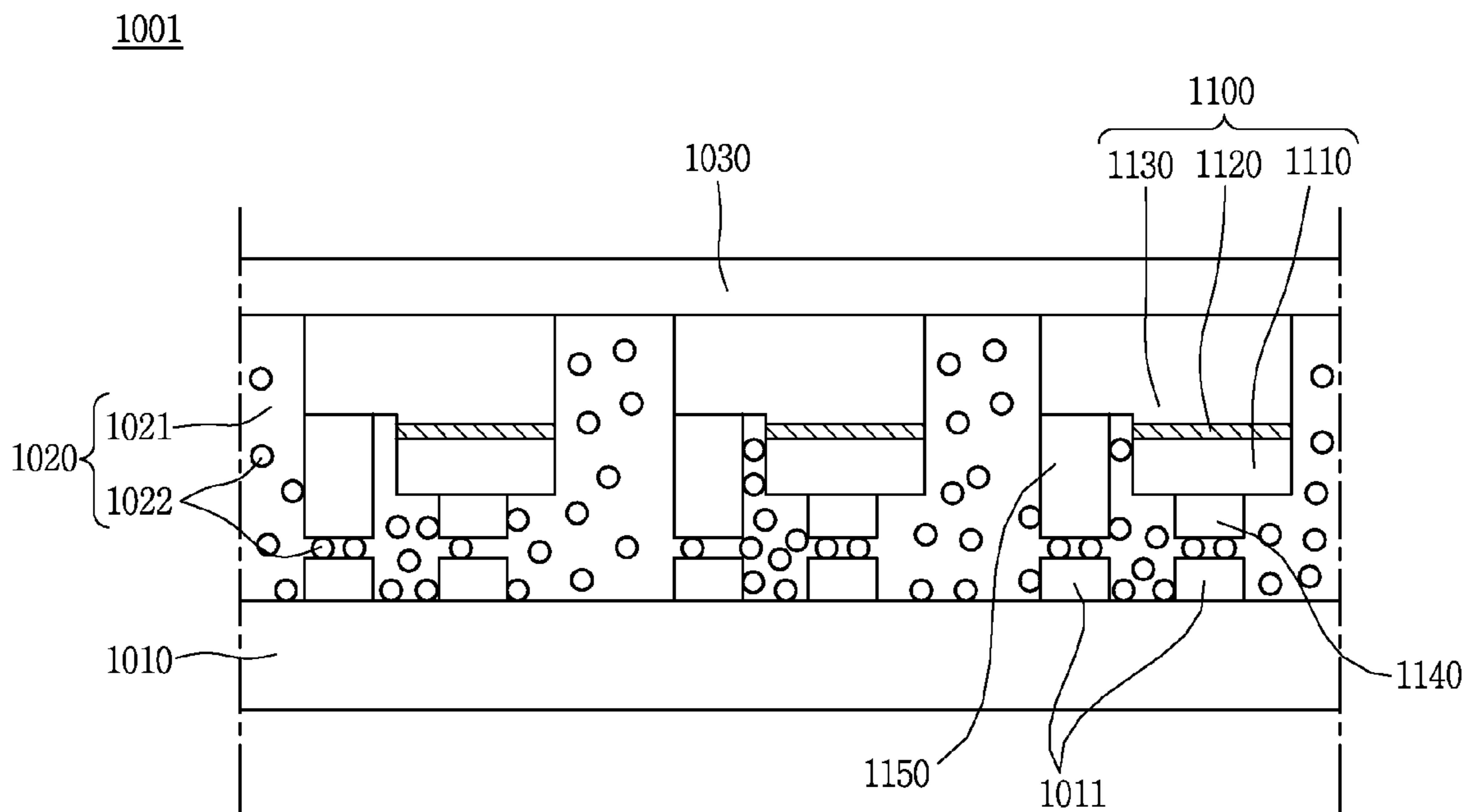


FIG. 18



DISPLAY DEVICE USING SEMICONDUCTOR LIGHT EMITTING DEVICE

CROSS-REFERENCE TO RELATED APPLICATIONS

Pursuant to 35 U.S.C. §119(a), this application claims the benefit of earlier filing date and right of priority to Korean Patent Application No. 10-2013-0098313, filed on Aug. 20, 2013, the contents of which is incorporated by reference herein in its entirety.

BACKGROUND OF THE INVENTION

1. Field of the Invention

The present disclosure relates to a display device, and more particularly, to a display device using a semiconductor light emitting device.

2. Description of the Related Art

In recent years, display devices having excellent characteristics such as low profile, flexibility and the like have been developed in the display technical field. On the contrary, currently commercialized main displays are represented by liquid crystal displays (LCDs) and active matrix organic light emitting diodes (AMOLEDs).

However, there exist problems such as not-so-fast response time, difficult implementation of flexibility in case of LCDs, and there exist drawbacks such as short life span, not-so-good yield as well as low flexibility in case of AMOLEDs.

On the other hand, light emitting diodes (LEDs) are well known light emitting devices for converting an electrical current to light, and have been used as a light source for displaying an image in an electronic device including information communication devices since red LEDs using GaAsP compound semiconductors were made commercially available in 1962, together with a GaP:N-based green LEDs. Accordingly, the semiconductor light emitting devices may be used to implement a flexible display, thereby presenting a scheme for solving the problems.

SUMMARY OF THE INVENTION

An aspect of the present disclosure is to provide a new type of display device with flexibility, which is different from the related art.

Another aspect of the present disclosure is to provide a display device having long life span, low power consumption, high efficiency and fast response time.

A display device according to an embodiment of the present disclosure may include a lower substrate disposed with a line electrode at an upper portion thereof, a plurality of semiconductor light emitting devices electrically connected to the line electrode to generate light and disposed to be separated from one another, and a conductive adhesive layer comprising a body configured to fix the location of the lower substrate to that of the semiconductor light emitting device, and conductors dispersed within the body to electrically connect the lower substrate to the semiconductor light emitting device, wherein the plurality of semiconductor light emitting devices form one pixel region (P) having red, green and blue semiconductor light emitting devices that emit red, green and blue light, and contain a material selected from inorganic semiconductor materials, and the conductive adhesive layer blocks light generated from the plurality of semiconductor light emitting devices.

Here, the semiconductor light emitting device may include a first conductive semiconductor layer, an active layer located

on the first conductive semiconductor layer, and a second conductive semiconductor layer located on the active layer.

Furthermore, the first and the second electrode may be in contact with at least part of the conductors.

On the other hand, the body of the conductive adhesive layer may be disposed to surround a lateral surface and a lower surface of the semiconductor light emitting device.

Furthermore, the body of the conductive adhesive layer may contain a material that absorbs light.

Furthermore, the body of the conductive adhesive layer may have mobility and be cured in any one of normal temperature, high temperature and catalyst atmosphere.

On the other hand, the red semiconductor light emitting device may have a composition formula of $(Al_x Ga_{1-x})_{0.5}In_{0.5}P$ or GaAsP.

Furthermore, the green semiconductor light emitting device may have a composition formula of GaP.

In addition, the blue semiconductor light emitting device may have a composition formula of $In_xAl_yGa_{1-x-y}N$ ($0 \leq x \leq 1$, $0 \leq y \leq 1$, $0 \leq x+y \leq 1$).

According to the present disclosure having the foregoing configuration, a distance between light emitting devices may be sufficiently large and the conductive adhesive layer may have softness, thereby implementing a rollable display device.

According to an embodiment, an inorganic semiconductor light emitting device may be disposed in a pixel region, thereby having an advantage capable of implementing a high-speed screen with a fast response time.

Furthermore, according to an embodiment, an additional back light may be not required, thereby having an advantage of excellent luminance and excellent efficiency.

Furthermore, the semiconductor light emitting device may be an inorganic material, thereby having an advantage of long life span.

Furthermore, according to an embodiment, the semiconductor light emitting device may be disposed in a pixel unit, thereby having an advantage of being implemented easily with an active type.

Furthermore, the first and the second electrode may be located at a lower region of the active layer generating light, thereby preventing light from being absorbed to the first and the second electrode.

Furthermore, the adhesive portion may block light generated from the semiconductor light emitting device, thereby suppressing optical interference between the pixel region and sub-pixel region.

Furthermore, a color filter for implementing color may be omitted, thereby advantage capable of fabricating a low-profile display device.

BRIEF DESCRIPTION OF THE DRAWINGS

FIG. 1 is a conceptual view illustrating a display device using a semiconductor light emitting device according to an embodiment of the present disclosure;

FIG. 2 is a partial enlarged view of portion "A" in FIG. 1;

FIGS. 3A and 3B are cross-sectional views taken along lines 3A-3A and 3B-3B in FIG. 2;

FIG. 4 is a conceptual view illustrating a flip-chip type semiconductor light emitting device in FIG. 3A;

FIGS. 5A through 5C are conceptual views illustrating various forms for implementing colors in connection with a flip-chip type semiconductor light emitting device;

FIG. 6 is cross-sectional views illustrating a method of fabricating a display device using a semiconductor light emitting device according to the present disclosure;

FIG. 7 is a perspective view illustrating a display device using a semiconductor light emitting device according to another embodiment of the present disclosure;

FIG. 8 is a cross-sectional view taken along line 8-8 in FIG. 7;

FIG. 9 is a conceptual view illustrating a vertical type semiconductor light emitting device in FIG. 8;

FIG. 10 is a partial cross-sectional view illustrating a display device according to an embodiment of the present disclosure;

FIG. 11 is a cross-sectional view taken along line 11-11 in FIG. 10;

FIG. 12 is a cross-sectional view illustrating a semiconductor light emitting device in FIG. 10; and

FIGS. 13 through 18 are a flow chart illustrating a method of fabricating a display device according to an embodiment.

DETAILED DESCRIPTION OF THE INVENTION

Advantages and features of the present disclosure, and methods of accomplishing the same will be clearly understood with reference to the following embodiments described in detail in conjunction with the accompanying drawings. However, the present disclosure is not limited to those embodiments disclosed below but may be implemented in various different forms. It should be noted that the present embodiments are merely provided to make a full disclosure of the invention and also to allow those skilled in the art to know the full range of the invention, and therefore, the present invention is to be defined only by the scope of the appended claims. Further, like reference numerals refer to like or similar elements throughout the specification.

Spatially relative terms such as “below”, “beneath”, “lower”, “above”, or “upper” may be used herein to describe a correlation between one device or constituent element and other devices or constituent elements as illustrated in the drawings. It will be understood that spatially relative terms are intended to include a different direction of device during the use or operation in addition to its direction illustrated in the drawings. For example, when a device in the drawing is turned over, the device described as “below” or “beneath” another device will be placed “above” the another device. Accordingly, the exemplary terms “below” or “beneath” may include both directions of above and below. Since the device may be oriented in another direction, and thus the spatially relative terms may be interpreted in accordance with the orientation thereof.

It should be noted that the terms used herein are merely used to describe the embodiments, but not to limit the present invention. In the present specification, unless clearly used otherwise, expressions in a singular form include a plural form. The term “comprises” and/or “comprising” used in the specification intend to express a constituent element, a step, an operation and/or a device does not exclude the existence or addition of one or more other constituent elements, steps, operations and/or devices.

In the drawings, the thickness or size of each layer is exaggerated, omitted, or schematically illustrated for the convenience and clarity of the description. Furthermore, the size or area of each constituent element does not definitely reflect the actual size or area thereof.

Furthermore, angles or directions used to describe the structure of a display device according to an embodiment are based on those shown in the drawings. Unless a reference point or positional relation with respect to an angle is not

clearly defined in describing a structure for implementing the display device in the specification, the associated drawings may be referred to.

Hereinafter, embodiments will be described in more detail with reference to the accompanying drawings.

Hereinafter, the embodiments disclosed herein will be described in detail with reference to the accompanying drawings, and the same or similar elements are designated with the same numeral references regardless of the numerals in the drawings and their redundant description will be omitted. A suffix “module” or “unit” used for constituent elements disclosed in the following description is merely intended for easy description of the specification, and the suffix itself does not give any special meaning or function. In describing the embodiments disclosed herein, moreover, the detailed description will be omitted when a specific description for publicly known technologies to which the invention pertains is judged to obscure the gist of the present invention. Also, it should be noted that the accompanying drawings are merely illustrated to easily explain the concept of the invention, and therefore, they should not be construed to limit the technological concept disclosed herein by the accompanying drawings.

Furthermore, it will be understood that when an element such as a layer, region or substrate is referred to as being “on” another element, it can be directly on the another element or an intermediate element may also be interposed therebetween.

A display device disclosed herein may include a portable phone, a smart phone, a laptop computer, a digital broadcast terminal, a personal digital assistant (PDA), a portable multimedia player (PMP), a navigation, a slate PC, a tablet PC, an ultrabook, a digital TV, a desktop computer, and the like. However, it would be easily understood by those skilled in the art that a configuration disclosed herein may be applicable to any displayable device even though it is a new product type which will be developed later.

FIG. 1 is a conceptual view illustrating a display device using a semiconductor light emitting device according to an embodiment of the present disclosure.

According to the drawing, information processed in the controller of the display device 100 may be displayed using a flexible display.

The flexible display may include a flexible, bendable, twistable, foldable and rollable display. For example, the flexible display may be a display fabricated on a thin and flexible substrate that can be warped, bent, folded or rolled like a paper sheet while maintaining the display characteristics of a flat display in the related art.

A display area of the flexible display becomes a plane in a configuration that the flexible display is not warped (for example, a configuration having an infinite radius of curvature, hereinafter, referred to as a “first configuration”). The display area thereof becomes a curved surface in a configuration that the flexible display is warped by an external force in the first configuration (for example, a configuration having a finite radius of curvature, hereinafter, referred to as a “second configuration”). As illustrated in the drawing, information displayed in the second configuration may be visual information displayed on a curved surface. The visual information may be implemented by individually controlling the light emission of sub-pixels disposed in a matrix form. The sub-pixel denotes a minimum unit for implementing one color.

The sub-pixel of the flexible display may be implemented by a semiconductor light emitting device. According to the present disclosure, a light emitting diode (LED) is illustrated

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as a type of semiconductor light emitting device. The light emitting diode may be formed with a small size to perform the role of a sub-pixel even in the second configuration through this.

Hereinafter, a flexible display implemented using the light emitting diode will be described in more detail with reference to the accompanying drawings.

FIG. 2 is a partial enlarged view of portion "A" in FIG. 1, and FIGS. 3A and 3B are cross-sectional views taken along lines 3A-3A and 3B-3B in FIG. 2, FIG. 4 is a conceptual view illustrating a flip-chip type semiconductor light emitting device in FIG. 3A, and FIGS. 5A through 5C are conceptual views illustrating various forms for implementing colors in connection with a flip-chip type semiconductor light emitting device.

According to the drawings in FIGS. 2, 3A and 3B, there is illustrated a display device 100 using a passive matrix (PM) type semiconductor light emitting device as a display device 100 using a semiconductor light emitting device. However, the following illustration may be also applicable to an active matrix (AM) type semiconductor light emitting device.

The display device 100 may include a substrate 110, a first electrode 120, a conductive adhesive layer 130, a second electrode 140, and a plurality of semiconductor light emitting devices 150.

The substrate 110 may be a flexible substrate. The substrate 110 may contain glass or polyimide (PI) to implement the flexible display device. In addition, if it is a flexible material, any one such as polyethylene naphthalate (PEN), polyethylene terephthalate (PET) or the like may be used. Furthermore, the substrate 110 may be either one of transparent and non-transparent materials.

The substrate 110 may be a wiring substrate disposed with the first electrode 120, and thus the first electrode 120 may be placed on the substrate 110.

According to the drawing, an insulating layer 160 may be disposed on the substrate 110 placed with the first electrode 120, and an auxiliary electrode 170 may be placed on the insulating layer 160. In this case, a configuration in which the insulating layer 160 is deposited on the substrate 110 may be single wiring substrate. More specifically, the insulating layer 160 may be incorporated into the substrate 110 with an insulating and flexible material such as polyimide (PI), PET, PEN or the like to form single wiring substrate.

The auxiliary electrode 170 as an electrode for electrically connecting the first electrode 120 to the semiconductor light emitting device 150 is placed on the insulating layer 160, and disposed to correspond to the location of the first electrode 120. For example, the auxiliary electrode 170 has a dot shape, and may be electrically connected to the first electrode 120 by means of an electrode hole 171 passing through the insulating layer 160. The electrode hole 171 may be formed by filling a conductive material in a via hole.

Referring to the drawings, the conductive adhesive layer 130 may be formed on one surface of the insulating layer 160, but the present disclosure may not be necessarily limited to this. For example, it may be possible to also have a structure in which the conductive adhesive layer 130 is disposed on the substrate 110 with no insulating layer 160. The conductive adhesive layer 130 may perform the role of an insulating layer in the structure in which the conductive adhesive layer 130 is disposed on the substrate 110.

The conductive adhesive layer 130 may be a layer having adhesiveness and conductivity, and to this end, a conductive material and an adhesive material may be mixed on the conductive adhesive layer 130. Furthermore, the conductive

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adhesive layer 130 may have flexibility, thereby allowing a flexible function in the display device.

For such an example, the conductive adhesive layer 130 may be an anisotropic conductive film (ACF), an anisotropic conductive paste, a solution containing conductive particles, and the like. The conductive adhesive layer 130 may allow electrical interconnection in the z-direction passing through the thickness thereof, but may be configured as a layer having electrical insulation in the horizontal x-y direction thereof. Accordingly, the conductive adhesive layer 130 may be referred to as a z-axis conductive layer (however, hereinafter referred to as a "conductive adhesive layer").

The anisotropic conductive film is a film with a form in which an anisotropic conductive medium is mixed with an insulating base member, and thus when heat and pressure are applied thereto, only a specific portion thereof may have conductivity by means of the anisotropic conductive medium. Hereinafter, heat and pressure are applied to the anisotropic conductive film, but other methods may be also available for the anisotropic conductive film to partially have conductivity. The methods may include applying only either one of heat and pressure thereto, UV curing, and the like.

Furthermore, the anisotropic conductive medium may be conductive balls or particles. According to the drawing, in the present embodiment, the anisotropic conductive film is a film with a form in which an anisotropic conductive medium is mixed with an insulating base member, and thus when heat and pressure are applied thereto, only a specific portion thereof may have conductivity by means of the conductive balls. The anisotropic conductive film may be in a state in which a core with a conductive material contains a plurality of particles coated by an insulating layer with a polymer material, and in this case, it may have conductivity by means of the core while breaking an insulating layer on a portion to which heat and pressure are applied. Here, the shape of a core may be modified to implement a layer being brought into contact with each other in the thickness direction of the film. For a more specific example, heat and pressure are applied to an anisotropic conductive film as a whole, and electrical connection in the z-axis direction is partially formed by a height difference from a mating object adhered by the use of the anisotropic conductive film.

For another example, an anisotropic conductive film may be in a state containing a plurality of particles in which a conductive material is coated on insulating cores. In this case, a portion to which heat and pressure are applied may be converted (pressed and adhered) to a conductive material to have conductivity in the thickness direction of the film. For still another example, it may be formed to have conductivity in the thickness direction of the film in which a conductive material passes through an insulating base member in the z-direction. In this case, the conductive material may have a pointed end portion.

According to the drawing, the anisotropic conductive film may be a fixed array anisotropic conductive film (ACF) configured with a form in which conductive balls are inserted into one surface of the insulating base member. More specifically, the insulating base member is formed of an adhesive material, and the conductive balls are intensively disposed at a bottom portion of the insulating base member, and when heat and pressure are applied thereto, the base member is modified along with the conductive balls, thereby having conductivity in the vertical direction thereof.

However, the present disclosure may not be necessarily limited to this, and the anisotropic conductive film may be all allowed to have a form in which conductive balls are randomly mixed with an insulating base member or a form

configured with a plurality of layers in which conductive balls are disposed at any one layer (double-ACF), and the like.

The anisotropic conductive paste as a form coupled to a paste and conductive balls may be a paste in which conductive balls are mixed with an insulating and adhesive base material. Furthermore, a solution containing conductive particles may be a solution in a form containing conductive particles or nano particles.

Referring to the drawing again, the second electrode **140** is located at the insulating layer **160** to be separated from the auxiliary electrode **170**. In other words, the conductive adhesive layer **130** is disposed on the insulating layer **160** located with the auxiliary electrode **170** and second electrode **140**.

When the conductive adhesive layer **130** is formed in a state that the auxiliary electrode **170** and second electrode **140** are located, and then the semiconductor light emitting device **150** is connect thereto in a flip chip form with the application of heat and pressure, the semiconductor light emitting device **150** is electrically connected to the first electrode **120** and second electrode **140**.

Referring to FIG. 4, the semiconductor light emitting device may be a flip chip type semiconductor light emitting device.

For example, the semiconductor light emitting device may include a p-type electrode **156**, a p-type semiconductor layer **155** formed with the p-type electrode **156**, an active layer **154** formed on the p-type semiconductor layer **155**, an n-type semiconductor layer **153** formed on the active layer **154**, and an n-type electrode **152** disposed to be separated from the p-type electrode **156** in the horizontal direction on the n-type semiconductor layer **153**. In this case, the p-type electrode **156** may be electrically connected to the welding portion **179** by the conductive adhesive layer **130**, and the n-type electrode **152** may be electrically connected to the second electrode **140**.

Referring to FIGS. 2, 3A and 3B again, the auxiliary electrode **170** may be formed in an elongated manner in one direction to be electrically connected to a plurality of semiconductor light emitting devices **150**. For example, the left and right p-type electrodes of the semiconductor light emitting devices around the auxiliary electrode may be electrically connected to one auxiliary electrode.

More specifically, the semiconductor light emitting device **150** is pressed into the conductive adhesive layer **130**, and through this, only a portion between the p-type electrode **156** and auxiliary electrode **170** of the semiconductor light emitting device **150** and a portion between the n-type electrode **152** and second electrode **140** of the semiconductor light emitting device **150** have conductivity, and the remaining portion does not have conductivity since there is no push-down of the semiconductor light emitting device.

Furthermore, a plurality of semiconductor light emitting devices **150** constitute a light-emitting array, and a phosphor layer **180** is formed on the light-emitting array.

The light emitting device may include a plurality of semiconductor light emitting devices with different self luminance values. Each of the semiconductor light emitting devices **150** constitutes a sub-pixel, and is electrically connected to the first electrode **120**. For example, there may exist a plurality of first electrodes **120**, and the semiconductor light emitting devices are arranged in several rows, for instance, and each row of the semiconductor light emitting devices may be electrically connected to any one of the plurality of first electrodes.

Furthermore, the semiconductor light emitting devices may be connected in a flip chip form, and thus semiconductor light emitting devices grown on a transparent dielectric sub-

strate. Furthermore, the semiconductor light emitting devices may be nitride semiconductor light emitting devices, for instance. The semiconductor light emitting device **150** has an excellent luminance characteristic, and thus it may be possible to configure individual sub-pixels even with a small size thereof.

According to the drawing, a partition wall **190** may be formed between the semiconductor light emitting devices **150**. In this case, the partition wall **190** may perform the role of dividing individual sub-pixels from one another, and be formed as an integral body with the conductive adhesive layer **130**. For example, a base member of the anisotropic conductive film may form the partition wall when the semiconductor light emitting device **150** is inserted into the anisotropic conductive film.

Furthermore, when the base member of the anisotropic conductive film is black, the partition wall **190** may have reflective characteristics while at the same time increasing contrast with no additional black insulator.

For another example, a reflective partition wall may be separately provided with the partition wall **190**. In this case, the partition wall **190** may include a black or white insulator according to the purpose of the display device. It may have an effect of enhancing reflectivity when the partition wall of the while insulator is used, and increase contrast while at the same time having reflective characteristics.

The phosphor layer **180** may be located at an outer surface of the semiconductor light emitting device **150**. For example, the semiconductor light emitting device **150** is a blue semiconductor light emitting device that emits blue (B) light, and the phosphor layer **180** performs the role of converting the blue (B) light into the color of a sub-pixel. The phosphor layer **180** may be a red phosphor layer **181** or green phosphor layer **182** constituting individual pixels.

In other words, a red phosphor **181** capable of converting blue light into red (R) light may be deposited on the blue semiconductor light emitting device **151** at a location implementing a red sub-pixel, and a green phosphor **182** capable of converting blue light into green (G) light may be deposited on the blue semiconductor light emitting device **151** at a location implementing a green sub-pixel. Furthermore, only the blue semiconductor light emitting device **151** may be solely used at a location implementing a blue sub-pixel. In this case, the red (R), green (G) and blue (B) sub-pixels may implement one pixel. More specifically, one color phosphor may be deposited along each line of the first electrode **120**. Accordingly, one line on the first electrode **120** may be an electrode controlling one color. In other words, red (R), green (B) and blue (B) may be sequentially disposed, thereby implementing sub-pixels.

However, the present disclosure may not be necessarily limited to this, and the semiconductor light emitting device **150** may be combined with a quantum dot (QD) instead of a phosphor to implement sub-pixels such as red (R), green (G) and blue (B).

Furthermore, a black matrix **191** may be disposed between each phosphor layer to enhance contrast. In other words, the black matrix **191** can enhance the contrast of luminance.

However, the present disclosure may not be necessarily limited to this, and another structure for implementing blue, red and green may be also applicable thereto.

Referring to FIG. 5A, each of the semiconductor light emitting devices **150** may be implemented with a high-power light emitting device that emits various lights including blue in which gallium nitride (GaN) is mostly used, and indium (In) and or aluminum (Al) are added thereto.

In this case, the semiconductor light emitting device **150** may be red, green and blue semiconductor light emitting devices, respectively, to implement each sub-pixel. For instance, red, green and blue semiconductor light emitting devices (R, G, B) are alternately disposed, and red, green and blue sub-pixels implement one pixel by means of the red, green and blue semiconductor light emitting devices, thereby implementing a full color display.

Referring to FIG. **5B**, the semiconductor light emitting device may have a white light emitting device (W) provided with a yellow phosphor layer for each element. In this case, a red phosphor layer **181**, a green phosphor layer **182** and blue phosphor layer **183** may be provided on the white light emitting device (W) to implement a sub-pixel. Furthermore, a color filter repeated with red, green and blue on the white light emitting device (W) may be used to implement a sub-pixel.

Referring to FIG. **5C**, it may be possible to also have a structure in which a red phosphor layer **181**, a green phosphor layer **182** and blue phosphor layer **183** may be provided on a ultra violet light emitting device (UV). In this manner, the semiconductor light emitting device can be used over the entire region up to ultra violet (UV) as well as visible light, and may be extended to a form of semiconductor light emitting device in which ultra violet (UV) can be used as an excitation source.

Taking the present example into consideration again, the semiconductor light emitting device **150** is placed on the conductive adhesive layer **130** to configure a sub-pixel in the display device. The semiconductor light emitting device **150** may have excellent luminance characteristics, and thus it may be possible to configure individual sub-pixels even with a small size thereof. The size of the individual semiconductor light emitting device **150** may be less than 80 μm in the length of one side thereof, and formed with a rectangular or square shaped element. In case of a rectangular shaped element, the size thereof may be less than 20 \times 80 μm .

Furthermore, even when a square shaped semiconductor light emitting device **150** with a length of side of 10 μm is used for a sub-pixel, it will exhibit a sufficient brightness for implementing a display device. Accordingly, for example, in case of a rectangular pixel in which one side of a sub-pixel is 600 μm in size, and the remaining one side thereof is 300 μm , a relative distance between the semiconductor light emitting devices becomes sufficiently large. Accordingly, in this case, it may be possible to implement a flexible display device having a HD image quality.

A display device using the foregoing semiconductor light emitting device will be fabricated by a new type of fabrication method. Hereinafter, the fabrication method will be described with reference to FIG. **6**.

FIG. **6** is cross-sectional views illustrating a method of fabricating a display device using a semiconductor light emitting device according to the present disclosure.

Referring to the drawing, first, the conductive adhesive layer **130** is formed on the insulating layer **160** located with the auxiliary electrode **170** and second electrode **140**. The insulating layer **160** is deposited on the first substrate **110** to form one substrate (or wiring substrate), and the first electrode **120**, auxiliary electrode **170** and second electrode **140** are disposed at the wiring substrate. In this case, the first electrode **120** and second electrode **140** may be disposed in a perpendicular direction to each other. Furthermore, the first substrate **110** and insulating layer **160** may contain glass or polyimide (PI), respectively, to implement a flexible display device.

The conductive adhesive layer **130** may be implemented by an anisotropic conductive film, for example, and to this end,

an anisotropic conductive film may be coated on a substrate located with the insulating layer **160**.

Next, a second substrate **112** located with a plurality of semiconductor light emitting devices **150** corresponding to the location of the auxiliary electrodes **170** and second electrodes **140** and constituting individual pixels is disposed such that the semiconductor light emitting device **150** faces the auxiliary electrode **170** and second electrode **140**.

In this case, the second substrate **112** as a growth substrate for growing the semiconductor light emitting device **150** may be a sapphire substrate or silicon substrate.

The semiconductor light emitting device may have a gap and size capable of implementing a display device when formed in the unit of wafer, and thus effectively used for a display device.

Next, the wiring substrate is thermally compressed to the second substrate **112**. For example, the wiring substrate and second substrate **112** may be thermally compressed to each other by applying an ACF press head. The wiring substrate and second substrate **112** are bonded to each other using the thermal compression. Only a portion between the semiconductor light emitting device **150** and the auxiliary electrode **170** and second electrode **140** may have conductivity due to the characteristics of an anisotropic conductive film having conductivity by thermal compression, thereby allowing the electrodes and semiconductor light emitting device **150** to be electrically connected to each other. At this time, the semiconductor light emitting device **150** may be inserted into the anisotropic conductive film, thereby forming a partition wall between the semiconductor light emitting devices **150**.

Next, the second substrate **112** is removed. For example, the second substrate **112** may be removed using a laser lift-off (LLO) or chemical lift-off (CLO) method.

Finally, the second substrate **112** is removed to expose the semiconductor light emitting devices **150** to the outside. Silicon oxide (SiOx) or the like may be coated on the wiring substrate coupled to the semiconductor light emitting device **150** to form a transparent insulating layer (not shown).

Furthermore, it may further include the process of forming a phosphor layer on one surface of the semiconductor light emitting device **150**. For example, the semiconductor light emitting device **150** may be a blue semiconductor light emitting device for emitting blue (B) light, and red or green phosphor for converting the blue (B) light into the color of the sub-pixel may form a layer on one surface of the blue semiconductor light emitting device.

The fabrication method or structure of a display device using the foregoing semiconductor light emitting device may be modified in various forms. For such an example, the foregoing display device may be applicable to a vertical semiconductor light emitting device. Hereinafter, the vertical structure will be described with reference to FIGS. **5** and **6**.

Furthermore, according to the following modified example or embodiment, the same or similar reference numerals are designated to the same or similar configurations to the foregoing example, and the description thereof will be substituted by the earlier description.

FIG. **7** is a perspective view illustrating a display device using a semiconductor light emitting device according to another embodiment of the present disclosure. FIG. **8** is a cross-sectional view taken along line **8-8** in FIG. **7**, and FIG. **9** is a conceptual view illustrating a vertical type semiconductor light emitting device in FIG. **8**.

According to the drawings, the display device may be display device using a passive matrix (PM) type of vertical semiconductor light emitting device.

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The display device may include a substrate **210**, a first electrode **220**, a conductive adhesive layer **230**, a second electrode **240** and a plurality of semiconductor light emitting devices **250**.

The substrate **210** as a wiring substrate disposed with the first electrode **220** may include polyimide (PI) to implement a flexible display device. In addition, any one may be used if it is an insulating and flexible material.

The first electrode **220** may be located on the substrate **210**, and formed with an electrode having a bar elongated in one direction. The first electrode **220** may be formed to perform the role of a data electrode.

The conductive adhesive layer **230** is formed on the substrate **210** located with the first electrode **220**. Similarly to a display device to which a flip chip type light emitting device is applied, the conductive adhesive layer **230** may be an anisotropic conductive film (ACF), an anisotropic conductive paste, a solution containing conductive particles, and the like. However, the present embodiment illustrates a case where the conductive adhesive layer **230** is implemented by an anisotropic conductive film.

When an anisotropic conductive film is located in a state that the first electrode **220** is located on the substrate **210**, and then heat and pressure are applied to connect the semiconductor light emitting device **250** thereto, the semiconductor light emitting device **250** is electrically connected to the first electrode **220**. At this time, the semiconductor light emitting device **250** may be preferably disposed on the first electrode **220**.

The electrical connection is generated because an anisotropic conductive film partially has conductivity in the thickness direction when heat and pressure are applied as described above. Accordingly, the anisotropic conductive film is partitioned into a portion having conductivity and a portion having no conductivity in the thickness direction thereof.

Furthermore, the anisotropic conductive film contains an adhesive component, and thus the conductive adhesive layer **230** implements a mechanical coupling as well as an electrical coupling between the semiconductor light emitting device **250** and the first electrode **220**.

In this manner, the semiconductor light emitting device **250** is placed on the conductive adhesive layer **230**, thereby configuring a separate sub-pixel in the display device. The semiconductor light emitting device **250** may have excellent luminance characteristics, and thus it may be possible to configure individual sub-pixels even with a small size thereof. The size of the individual semiconductor light emitting device **250** may be less than 80 μm in the length of one side thereof, and formed with a rectangular or square shaped element. In case of a rectangular shaped element, the size thereof may be less than 20 \times 80 μm .

The semiconductor light emitting device **250** may be a vertical structure.

A plurality of second electrodes **240** disposed in a direction crossed with the length direction of the first electrode **220**, and electrically connected to the vertical semiconductor light emitting device **250** may be located between vertical semiconductor light emitting devices.

Referring to FIG. 9, the vertical semiconductor light emitting device may include a p-type electrode **256**, a p-type semiconductor layer **255** formed with the p-type electrode **256**, an active layer **254** formed on the p-type semiconductor layer **255**, an n-type semiconductor layer **253** formed on the active layer **254**, and an n-type electrode **252** formed on the n-type semiconductor layer **253**. In this case, the p-type electrode **256** located at the bottom thereof may be electrically

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connected to the first electrode **220** by the conductive adhesive layer **230**, and the n-type electrode **252** located at the top thereof may be electrically connected to the second electrode **240** which will be described later. The electrodes may be disposed in the upward/downward direction in the vertical semiconductor light emitting device **250**, thereby providing a great advantage capable of reducing the chip size.

Referring to FIG. 8 again, a phosphor layer **280** may be formed on one surface of the semiconductor light emitting device **250**. For example, the semiconductor light emitting device **250** is a blue semiconductor light emitting device **251** that emits blue (B) light, and the phosphor layer **280** for converting the blue (B) light into the color of the sub-pixel may be provided thereon. In this case, the phosphor layer **280** may be a red phosphor **281** and a green phosphor **282** constituting individual pixels.

In other words, a red phosphor **281** capable of converting blue light into red (R) light may be deposited on the blue semiconductor light emitting device **251** at a location implementing a red sub-pixel, and a green phosphor **282** capable of converting blue light into green (G) light may be deposited on the blue semiconductor light emitting device **251** at a location implementing a green sub-pixel. Furthermore, only the blue semiconductor light emitting device **251** may be solely used at a location implementing a blue sub-pixel. In this case, the red (R), green (G) and blue (B) sub-pixels may implement one pixel.

However, the present disclosure may not be necessarily limited to this, and another structure for implementing blue, red and green may be also applicable thereto as described above in a display device to which a flip chip type light emitting device is applied.

Taking the present embodiment into consideration again, the second electrode **240** is located between the semiconductor light emitting devices **250**, and electrically connected to the semiconductor light emitting devices **250**. For example, the semiconductor light emitting devices **250** may be disposed in a plurality of rows, and the second electrode **240** may be located between the rows of the semiconductor light emitting devices **250**.

Since a distance between the semiconductor light emitting devices **250** constituting individual pixels is sufficiently large, the second electrode **240** may be located between the semiconductor light emitting devices **250**.

The second electrode **240** may be formed with an electrode having a bar elongated in one direction, and disposed in a perpendicular direction to the first electrode.

Furthermore, the second electrode **240** may be electrically connected to the semiconductor light emitting device **250** by a connecting electrode protruded from the second electrode **240**. More specifically, the connecting electrode may be an n-type electrode of the semiconductor light emitting device **250**. For example, the n-type electrode is formed with an ohmic electrode for ohmic contact, and the second electrode covers at least part of the ohmic electrode by printing or deposition. Through this, the second electrode **240** may be electrically connected to the n-type electrode of the semiconductor light emitting device **250**.

According to the drawing, the second electrode **240** may be located on the conductive adhesive layer **230**. According to circumstances, a transparent insulating layer (not shown) containing silicon oxide (SiO_x) may be formed on the substrate **210** formed with the semiconductor light emitting device **250**. When the transparent insulating layer is formed and then the second electrode **240** is placed thereon, the second electrode **240** may be located on the transparent insulating layer. Furthermore, the second electrode **240** may be

formed to be separated from the conductive adhesive layer **230** or transparent insulating layer.

If a transparent electrode such as indium tin oxide (ITO) is used to locate the second electrode **240** on the semiconductor light emitting device **250**, the ITO material has a problem of bad adhesiveness with an n-type semiconductor. Accordingly, the second electrode **240** may be placed between the semiconductor light emitting devices **250**, thereby obtaining an advantage in which the transparent electrode is not required. Accordingly, an n-type semiconductor layer and a conductive material having a good adhesiveness may be used as a horizontal electrode without being restricted by the selection of a transparent material, thereby enhancing the light extraction efficiency.

According to the drawing, a partition wall **290** may be formed between the semiconductor light emitting devices **250**. In other words, the partition wall **290** may be disposed between the vertical semiconductor light emitting devices **250** to isolate the semiconductor light emitting device **250** constituting individual pixels. In this case, the partition wall **290** may perform the role of dividing individual sub-pixels from one another, and be formed as an integral body with the conductive adhesive layer **230**. For example, a base member of the anisotropic conductive film may form the partition wall when the semiconductor light emitting device **250** is inserted into the anisotropic conductive film.

Furthermore, when the base member of the anisotropic conductive film is black, the partition wall **290** may have reflective characteristics while at the same time increasing contrast with no additional black insulator.

For another example, a reflective partition wall may be separately provided with the partition wall **290**. In this case, the partition wall **290** may include a black or white insulator according to the purpose of the display device.

If the second electrode **240** is precisely located on the conductive adhesive layer **230** between the semiconductor light emitting devices **250**, the partition wall **290** may be located between the semiconductor light emitting device **250** and second electrode **240**. Accordingly, individual sub-pixels may be configured even with a small size using the semiconductor light emitting device **250**, and a distance between the semiconductor light emitting devices **250** may be relatively sufficiently large to place the second electrode **240** between the semiconductor light emitting devices **250**, thereby having the effect of implementing a flexible display device having a HD image quality.

Furthermore, according to the drawing, a black matrix **291** may be disposed between each phosphor layer to enhance contrast. In other words, the black matrix **191** can enhance the contrast of luminance.

As described above, the semiconductor light emitting device **250** is located on the conductive adhesive layer **230**, thereby constituting individual pixels on the display device. Since the semiconductor light emitting device **250** has excellent luminance characteristics, thereby configuring individual sub-pixels even with a small size thereof. As a result, it may be possible to implement a full color display in which the sub-pixels of red (R), green (G) and blue (B) implement one pixel by means of the semiconductor light emitting device.

As described above, in a display device using a semiconductor light emitting device according to the present disclosure, a structure in which red, green and blue semiconductor light emitting devices form a sub-pixel may be taken into consideration as illustrated in FIG. 5A, and hereinafter, the structure will be described in more detail.

FIG. 10 is a partial cross-sectional view illustrating a display device according to an embodiment of the present dis-

closure, and FIG. 11 is a cross-sectional view taken along line 11-11 in FIG. 10, and FIG. 12 is a cross-sectional view illustrating a semiconductor light emitting device in FIG. 10. Referring to FIGS. 10 and 11, a display device **1001** may include a lower substrate **1010** disposed with a line electrode **1011** at an upper portion thereof, a plurality of semiconductor light emitting devices **1100** located on the line electrode **1011** to generate light, and a conductive adhesive layer **1020** including a body **1021** configured to fix the location of the lower substrate **1010** to that of the semiconductor light emitting device **1100**, and conductors **1022** dispersed within the body **1021** to electrically connect the lower substrate **1010** to the semiconductor light emitting device **1100**.

The lower substrate **1010** may have a film shape with an insulating material. For example, the lower substrate **1010** may be made of a glass material or made of a transparent plastic or polymer film with excellent flexibility.

More specifically, the lower substrate **1010** may be a flexible substrate. For example, the lower substrate **1010** may include glass or polyimide (PI) to implement a flexible display device. In addition, any one may be used if it is an insulating and flexible material, for example, polyethylene naphthalate (PEN), polyethylene terephthalate (PET), and the like. Furthermore, the lower substrate **1010** may include either one of a transparent and a non-transparent material as illustrated in FIG. 5A.

A line electrode **1011** may be disposed at a location corresponding to the semiconductor light emitting device **1100** on a lower substrate **1010** thereof.

The line electrode **1011** may commonly refer to a second electrode **140** (refer to FIG. 3A) and an auxiliary electrode **170** (refer to FIG. 3A) on the substrate described with reference to FIGS. 3A and 3B.

More specifically, the line electrode **1011** may be disposed to correspond to (be vertically overlapped with) a location of the first conductive electrode **1140** and a second conductive electrode **1150** of the semiconductor light emitting device **1100**. Furthermore, the line electrode **1011** may be formed to be protruded in the direction of the semiconductor light emitting device **1100** from the lower substrate **1010** to facilitate a contact between the first electrode **1140** and second electrode **1150** of the semiconductor light emitting device **1100**. Of course, the line electrode **1011** may be buried and exposed on the lower substrate **1010**. However, the present disclosure may not be necessarily limited to this.

The line electrode **1011** may include a conductive material, and for example, a metal selected from a group consisting of In, Co, Si, Ge, Au, Pd, Pt, Ru, Re, Mg, Zn, Hf, Ta, Rh, Ir, W, Ti, Ag, Cr, Mo, Nb, Al, Ni, Cu, and WTi, or include an alloy thereof, and formed with a single layer or multiple layers. Otherwise, the line electrode **1011** may be formed of a light transmitting material, and for example, formed by including at least one of ITO, IZO(In—ZnO), GZO(Ga—ZnO), AZO(Al—ZnO), AGZO(Al—Ga ZnO), IGZO(In—Ga ZnO), IrOx, RuOx, RuOx/ITO, Ni/IrOx/Au and Ni/IrOx/Au/ITO.

The line electrode **1011** is formed using a deposition method such as sputtering the foregoing conductive material on the lower substrate **1010**. Subsequently, a metal layer may be patterned and formed with a photolithographic process or etching process using a mask.

The line electrodes **1011** may be disposed to be crossed with each other, and a switching element (not shown) may be located at the foregoing cross-section.

The line electrode **1011** may be disposed in consideration of a pixel region (P) which will be described later.

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Referring to FIGS. 10 and 12, the semiconductor light emitting device 1100 is located to correspond to the pixel region (P) on the line electrode 1011.

The pixel region (P) may be formed in such a manner that a plurality of semiconductor light emitting devices constitute a group.

The plurality of semiconductor light emitting devices 1100 may be disposed to be separated from each other in a stripe form along each row direction.

Furthermore, the plurality of semiconductor light emitting devices 1100 may form one pixel region (P) made of a red semiconductor light emitting device (R) 1100 that emits red light (about 700 nm in wavelength), a green semiconductor light emitting device (G) 1100 that emits green light (about 550 nm in wavelength), and a blue semiconductor light emitting device (B) 1100 that emits blue light (about 440 nm in wavelength) to generate various colors with a mixed color of the red semiconductor light emitting device (R) 1100, green semiconductor light emitting device (G) 1100, and blue semiconductor light emitting device (B) 1100. One pixel region (P) may be the foregoing sub-pixel, and a plurality of pixel regions (P) may display various images.

For example, when all the red semiconductor light emitting device (R) 1100, green semiconductor light emitting device (G) 1100, and blue semiconductor light emitting device (B) 1100 emit light, the pixel region (P) may emit white light. Furthermore, when the green semiconductor light emitting device (G) 1100 and blue semiconductor light emitting device (B) 1100, the pixel region (P) may emit white light.

The semiconductor light emitting device 1100 may be a semiconductor including an inorganic material.

In case of a liquid crystal display, there exist a problem such as not-so-fast response time, high current consumption due to a low efficiency of backlight unit, no guarantee of the two-year life span due to low reliability in organic materials in case of organic light emitting diodes (OLEDs), and very low yield of mass production.

According to an embodiment, an inorganic semiconductor light emitting device 1100 may be disposed at the pixel region (P), thereby having an advantage capable of implementing a high-speed screen with a fast response time.

Furthermore, an additional back light may be not required, thereby having an advantage of excellent luminance and excellent efficiency.

Furthermore, the semiconductor light emitting device 1100 may be an inorganic material, thereby having an advantage of long life span.

Furthermore, according to an embodiment, the semiconductor light emitting device 1100 may be disposed in a pixel unit, thereby having an advantage of being implemented easily with an active type.

The semiconductor light emitting devices 1100 may individually emit red, green and blue light, thereby having an advantage of not providing an additional color substrate.

For example, semiconductor light emitting device 1100 may be formed using a method such as metal organic chemical vapor deposition (MOCVD), chemical vapor deposition (CVD), plasma-enhanced chemical vapor deposition (PECVD), molecular beam epitaxy (MBE), hydride vapor phase epitaxy (HVPE), sputtering, and the like, but may not be necessarily limited to this.

For example, the semiconductor light emitting device 1100 may include a first conductive semiconductor layer 1110, an active layer 1120 located on the first conductive semiconductor layer 1110, and a second conductive semiconductor layer 1130 located on the active layer 1120.

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The red semiconductor light emitting device (R) 1100, green semiconductor light emitting device (G) 1100 and blue semiconductor light emitting device (B) 1100 have the same structure, but there exists a difference between their composition materials. Hereinafter, unless specified otherwise, the description of the semiconductor light emitting device 1100 may be commonly applicable to the red semiconductor light emitting device (R) 1100, green semiconductor light emitting device (G) 1100, and blue semiconductor light emitting device (B) 1100.

The first conductive semiconductor layer 1110 may be formed of a semiconductor compound and doped with a first conductive dopant. For example, the first conductive semiconductor layer 1110 may be implemented with an n-type semiconductor layer, and electrons may be provided to the active layer 1120.

For example, the first conductive semiconductor layer 1110 of the red semiconductor light emitting device (R) 1100 may be selected from a semiconductor material having a composition formula of $(Al_xGa_{1-x})_{0.5}In_{0.5}P$ or GaAsP, for example, GaAsP, GaInP, AlInP and the like, and an n-type dopant such as Si, Ge, Sn, Se, Te and the like may be doped therein. Furthermore, the first conductive semiconductor layer 1110 of the green semiconductor light emitting device (G) 1100 may include GaP, and an n-type dopant such as Si, Ge, Sn, Se, Te and the like may be doped therein. Furthermore, the first conductive semiconductor layer 1110 of the blue semiconductor light emitting device (R) 1100 may be selected from a semiconductor material having a composition formula of $In_xAl_yGa_{1-x-y}N$ ($0 \leq x \leq 1$, $0 \leq y \leq 1$, $0 \leq x+y \leq 1$), for example, GaN, AlN, AlGaN, InGaN, InN, InAlGaN, AlInN and the like, and an n-type dopant such as Si, Ge, Sn, Se, Te and the like may be doped therein.

For another example, both the first conductive semiconductor layers 1110 of the red semiconductor light emitting device (R) 1100 and green semiconductor light emitting device (G) 1100 may include GaAsP, and there may exist a difference in the content of P. However, it may not be necessarily limited to this.

The active layer 1120 may be formed on the first conductive semiconductor layer 1110. The active layer 1120 is a region in which electrons are recombined with holes, and transits to a low energy level when electrons and holes are recombined, thereby generating light having a wavelength corresponding to this. Meanwhile, the active layer 1120 may be formed with a single or multiple quantum well structure, a quantum wire structure or quantum dot structure, and the like using a compound semiconductor material.

When the active layer 1120 is formed with a quantum well structure, it may have a single or multiple quantum well structure having a well layer and a barrier layer. The well layer may be formed of a material having a band gap lower than that of the barrier layer.

Furthermore, when the active layer 1120 is formed with a multiple quantum well structure, each well layer (not shown) may have a different band gap.

For example, the active layer 1120 of the red semiconductor light emitting device (R) 1100 may be selected from a semiconductor material having a composition formula of $(Al_xGa_{1-x})_{0.5}In_{0.5}P$ or GaAsP, for example, GaAsP, GaInP, AlInP and the like. Furthermore, the active layer 1120 of the green semiconductor light emitting device (G) 1100 may include GaP. Furthermore, the active layer 1120 of the blue semiconductor light emitting device (R) 1100 may be selected from a semiconductor material having a composition

formula of $\text{In}_x\text{Al}_y\text{Ga}_{1-x-y}\text{N}$ ($0 \leq x \leq 1$, $0 \leq y \leq 1$, $0 \leq x+y \leq 1$), for example, GaN, AlN, AlGaN, InGaN, InN, InAlGaN, AlInN and the like.

For another example, both the active layers **1120** of the red semiconductor light emitting device (R) **1100** and green semiconductor light emitting device (G) **1100** may include GaAsP, and there may exist a difference in the content of P. However, it may not be necessarily limited to this.

A conductive clad layer (not shown) may be formed above or/and below the active layer **1120**. The conductive clad layer (not shown) may be formed of a semiconductor, and may have a band gap greater than that of the active layer **1120**. For example, the conductive clad layer (not shown) may be formed to contain AlGaN.

The second conductive semiconductor layer **1130** may be formed of a semiconductor compound to inject holes to the active layer **1120**, and a second conductive dopant may be doped therein. For example, the second conductive semiconductor layer **1130** may be implemented with a p-type semiconductor layer.

For example, the second conductive semiconductor layer **1130** of the red semiconductor light emitting device (R) **1100** may be selected from a semiconductor material having a composition formula of $(\text{Al}_x\text{Ga}_{1-x})_{0.5}\text{In}_{0.5}\text{P}$ or GaAsP, for example, GaAsP, GaInP, AlInP and the like, and a p-type dopant such as Mg, Zn, Ca, Sr, Ba and the like may be doped therein. Furthermore, the second conductive semiconductor layer **1130** of the green semiconductor light emitting device (G) **1100** may include GaP, and a p-type dopant such as Mg, Zn, Ca, Sr, Ba and the like may be doped therein.

Furthermore, the second conductive semiconductor layer **1130** of the blue semiconductor light emitting device (R) **1100** may be selected from a semiconductor material having a composition formula of $\text{In}_x\text{Al}_y\text{Ga}_{1-x-y}\text{N}$ ($0 \leq x \leq 1$, $0 \leq y \leq 1$, $0 \leq x+y \leq 1$), for example, GaN, AlN, AlGaN, InGaN, InN, InAlGaN, AlInN and the like, and a p-type dopant such as Mg, Zn, Ca, Sr, Ba and the like may be doped therein.

For another example, both the second conductive semiconductor layers **1130** of the red semiconductor light emitting device (R) **1100** and green semiconductor light emitting device (G) **1100** may include GaAsP, and there may exist a difference in the content of P. However, it may not be necessarily limited to this.

On the other hand, an electron blocking layer (not shown) may be formed between the active layer **1120** and second conductive semiconductor layer **1130**, and the electron blocking layer may prevent a phenomenon in which electrons injected to the active layer **1120** from the first conductive semiconductor layer **1110** during the application of a high current flow to the second conductive semiconductor layer **1130** without being recombined at the active layer **1120**. The electron blocking layer may have a band gap relatively greater than that of the active layer **1120**, thereby preventing a phenomenon in which electrons injected from the first conductive semiconductor layer **1110** are injected to the second conductive semiconductor layer **1130** without being recombined at the active layer **1120**. Accordingly, it may be possible to increase a probability of recombining electrons with holes at the active layer **1120** as well as suppress a leakage current.

Furthermore, the first conductive semiconductor layer **1110** may be implemented with a p-type semiconductor layer, and the second conductive semiconductor layer **1130** may be implemented with an n-type semiconductor layer, and a third semiconductor layer (not shown) including an n-type or p-type semiconductor layer having an opposite polarity to that of the second conductive semiconductor layer **1130** may be formed on the second conductive semiconductor layer

1130. Accordingly, the light emitting device may have at least any one of np, pn, npn, pnp junction structures.

A light transmitting electrode layer (not shown) may be formed on a lower surface of the first conductive semiconductor layer **1110**. The transparent electrode layer may be formed by including at least one of ITO, IZO(In—ZnO), GZO(Ga—ZnO), AZO(Al—ZnO), AGZO(Al—Ga ZnO), IGZO(In—Ga ZnO), IrOx, RuOx, RuOx/ITO, Ni/IrOx/Au and Ni/IrOx/Au/ITO. Accordingly, the transparent electrode layer may be formed on the entire or partial lower surface of the first conductive semiconductor layer **1110**, thereby preventing a current crowding phenomenon.

On the other hand, a first electrode **1140** electrically connected to the first conductive semiconductor layer **1110** may be disposed at the first conductive semiconductor layer **1110**. For example, the first electrode **1140** may be formed on a lower surface of the first conductive semiconductor layer **1110**.

Furthermore, a second electrode **1150** electrically connected to the second conductive semiconductor layer **1130** may be disposed at the second conductive semiconductor layer **1130**.

For example, part of the active layer **1120** and first conductive semiconductor layer **1110** may be removed to expose part of a lower surface of the second conductive semiconductor layer **1130**, and the first electrode **1140** may be formed on the exposed lower surface of the second conductive semiconductor layer **1130**. Meanwhile, a method of exposing part of the first conductive semiconductor layer **1110** may use a predetermined etching method, but may not be necessarily limited to this. Furthermore, a wet or dry etching method may be used for the etching method.

The first electrode **1140** and second electrode **1150** may be formed with a deposition method such as sputtering and the like. However, it may not be necessarily limited to this.

The first electrode **1140** and second electrode **1150** may be disposed to be protruded in the direction of the lower substrate **1010** in the semiconductor light emitting device **1100**. Furthermore, the lower surfaces of the first electrode **1140** and second electrode **1150** may be disposed on the same plane, thereby providing stability when the line electrode **1011** of the lower substrate **1010** is adhered to the semiconductor light emitting device **1100**.

Furthermore, the first electrode **1140** and second electrode **1150** may be located in a lower region of the active layer **1120**.

Since light generated from the active layer **1120** is not absorbed to the first electrode **1140** and second electrode **1150** while being advanced in the upward direction, thereby preventing the reduction of luminance and brightness from being caused due to an absorption of light into the first electrode **1140** and second electrode **1150**.

On the other hand, the first electrode **1140** and second electrode **1150** may include a conductive material, and for example, a metal selected from a group consisting of In, Co, Si, Ge, Au, Pd, Pt, Ru, Re, Mg, Zn, Hf, Ta, Rh, Ir, W, Ti, Ag, Cr, Mo, Nb, Al, Ni, Cu, and WTi, or include an alloy thereof, and formed with a single layer or multiple layers, but may not be necessarily limited to this.

On the other hand, a lower surface of the first conductive semiconductor layer **1110** may further include a reflective layer **1160**. Specifically, the reflective layer **1160** may be disposed in a region excluding a region in which the first electrode **1140** is located at a lower surface of the first conductive semiconductor layer **1110**.

The reflective layer **1160** may form a structure in which layers with different refractive indices are deposited in an

alternately repeated manner. For example, the reflective layer **1160** may at least include a first layer **1161** having a first refractive index and a second layer **1162** having a second refractive index different from the first refractive index. The first layer **1161** of the reflective layer **1160** may be a high refractive index layer and the second layer **1162** thereof may be a low refractive index layer. On the contrary, the first layer **1161** thereof may be a low refractive index layer, and the second layer **1162** thereof may be a high refractive index layer, but it may not be necessarily limited to this. The reflective layer **1160** may be deposited with 2 to 30 layers, but may not be necessarily limited to this.

In case where λ is a reference wavelength of light generated from the semiconductor light emitting device **1100**, n is a refractive index of the medium, and m is an odd number, the reflective layer **1160** may be formed with a deposition layer in which the first layer **1161** having a high refractive index with a thickness of $m\lambda/4n$ and the second layer **1162** having a low refractive index are deposited in an alternately repeated manner to obtain a reflective ratio greater than 95% over a specific bandwidth band of light.

The first layer **1161** having a high refractive index and the second layer **1162** having a low refractive index may have a thickness of $\lambda/4$ of the reference wavelength, and herein, each layer **1161**, **1162** may be formed with a thickness of 2 Å to 10 μm. Furthermore, the thickness of the reflective layer **1160** may be 100 to 10000 Å, but may not be necessarily limited to this, and may be also less or greater than that. In addition, each layer **1161**, **1162** forming the reflective layer **1160** may be formed of $MxOy$ (M: Metal, O: Oxide, X, Y: constant). For example, the reflective layer **1160** may include any one of SiO_2 , Al_2O_3 , SiC, AlB, BN and TiO_2 . However, it may not be necessarily limited to this. For example, the first layer **1161** having a high refractive index may include TiO_2 having a refractive index greater than 2 or the like, and the second layer **1162** having a low refractive index may include SiO_2 with a refractive index of 1.4 or Al_2O_3 with a refractive index of 1.6. On the contrary, in case where the first layer **1161** has a low refractive index and the second layer **1162** has a high refractive index, the first layer **1161** may include SiO_2 or Al_2O_3 and the second layer **1162** may include TiO_2 , but it may not be necessarily limited to this.

Accordingly, light generated from the active layer **1120** may be reflected on reflective layer **1160** to distribute light in the upward direction.

Referring to FIGS. **10** and **11** again, the conductive adhesive layer **1020** may be formed on one surface of the lower substrate **1010**.

The conductive adhesive layer **1020** may be a layer having adhesiveness and conductivity, and to this end, a material having conductivity and a material having adhesiveness may be mixed at the conductive adhesive layer **1020**. Furthermore, the conductive adhesive layer **1020** may have softness, thereby allowing a flexible function in a display device.

According to the drawing, the conductive adhesive layer **1020** according to the present example may include a body **1021** configured to fix the location of the lower substrate **1010** to that of the semiconductor light emitting device **1100**, and conductors **1022** dispersed within the body **1021** to electrically connect the lower substrate **1010** to the semiconductor light emitting device **1100**.

The conductive adhesive layer **1020** may include conductors **1022** having electrical conductivity. The conductive adhesive layer **1020** may be disposed such that the conductors **1022** are dispersed within the body **1021** having viscosity.

The conductive adhesive layer **1020** may be an anisotropic conductive film (ACF) made of an adhesive resin mixture containing the conductors **1022**.

According to the present example, it is illustrated a case where the conductive adhesive layer **1020** is an anisotropic conductive film (ACF), and the anisotropic conductive film is formed in such a manner that conductive balls are randomly intermixed in an insulating base member. However, the present disclosure may not be necessarily limited to this, various forms of the conductive adhesive layer described with reference to FIGS. **3A** and **3B** may be all applicable to the present example. For such an example, the anisotropic conductive film may be formed with a fixed array anisotropic conductive film (ACF) or with a form in which the insulating base member is configured with a plurality of layers and conductive balls are disposed in any one layer thereof (double ACF), and the like.

The body **1021** having viscosity may be a resin mixture. For example, the body **1021** may include silicon (Si) resin, epoxy or acrylic resin.

The body **1021** may have electrical insulation. Furthermore, the body **1021** may have mobility.

The body **1021** may have adhesiveness. The body **1021** may include a thermoplastic adhesive such as styrene-based block copolymer, and the like, but may not be necessarily limited to this.

Furthermore, the body **1021** may include a thermosetting adhesive material such as epoxy resin and the like. The body **1021** may control its adhesiveness by controlling thickness, viscosity, flexibility, adhesion, impurity, elasticity, and the like.

Furthermore, the body **1021** may include a material for blocking a short wavelength region of light (blue light, ultra violet (UV) rays). For example, the body **1021** may include zinc oxide or titanium dioxide.

Furthermore, the body **1021** may include a material for blocking light generated from the semiconductor light emitting device **1100**. For example, the body **1021** may include a non-transmitting synthetic resin that absorbs light.

Furthermore, the body **1021** may have black color. To this end, the body **1021** may include a material having black color. Accordingly, a region excluding the pixel region (P) is exhibited as black, thereby displaying a clear screen with a high contrast ratio.

The body **1021** blocks light generated from the semiconductor light emitting device **1100** to suppress optical interference between the adjoining pixel regions (Ps) and external light reflection.

The body **1021** may have mobility and thus be cured at a normal and high temperature, and cured by catalysis. Here, the high temperature denotes a temperature higher than the normal temperature.

The body **1021** may be disposed to surround at least the first electrode **1140** and second electrode **1150**. More preferably, the body **1021** may be disposed to surround the first electrode **1140** and second electrode **1150** and a lateral surface and a lower surface of the semiconductor light emitting device **1100**.

The body **1021** may perform the role of electrically connecting the first and the second electrode **1140**, **1150** to the line electrode **1011**, and adhering the lower substrate **1010** to the semiconductor light emitting device **1100**, and surround the semiconductor light emitting device **1100** to block optical interference between the semiconductor light emitting devices **1100**.

On the other hand, the body **1021** may be a transparent material. Accordingly, it may be possible to implement a display device with high transmittance and high luminance characteristics.

Furthermore, the body **1021** may isolate the semiconductor light emitting device **1100** from the outside to perform the role of protecting the semiconductor light emitting device **1100**.

The location of conductors **1022** located within the body **1021** may be moved according to a pressure applied by the outside. The adhesive portion **1020** may be formed such that conductors **1022** are disposed in a regular or irregular manner within the body **1021**.

The adhesive portion **1020** may control the size, shape, charge amount, dispersion state, thickness and the like of the conductors **1022** to change their conductivity. The adhesive portion **1020** may be changed in its thermal conductivity, adhesiveness, mobility and the like according to an increase of the content of the conductors **1022**.

The conductors **1022** may be a metal particles such as nickel or particles in which a metal is coated on a resin, but may not be necessarily limited to the kinds thereof. In case of particles in which a metal is coated on a resin, the conductors **1022** may be formed such that a conductive material such as nickel, gold or the like are coated on a surface of polymer core body such as polystyrene resin, acrylic resin and the like.

The conductors **1022** may be disposed adjacent to the first electrode **1140**, second electrode **1150** and line electrode **1011** to electrically connect the first electrode **1140** and second electrode **1150** to the line electrode **1011**.

Specifically, the conductors **1022** may be located between the first electrode **1140** and second electrode **1150** and the line electrode **1011**.

In other words, the adhesive portion **1020** may be formed such that the conductors **1022** are randomly located on the body **1021** having mobility, adhesiveness, and non-transparency.

The body **1021** having mobility is filled between the semiconductor light emitting device **1100** and lower substrate **1010** to selectively conduct the line electrode **1011** and semiconductor light emitting device **1100**, and cured to fix the location of the semiconductor light emitting device **1100** to that of the lower substrate **1010**.

A protective substrate **1030** for protecting the semiconductor light emitting device **1100** may be further provided on the semiconductor light emitting device **1100** and adhesive portion **1020**.

The protective substrate **1030** may include a synthetic resin with a light transmitting material.

FIGS. **13** through **18** are a flow chart illustrating a method of fabricating a display device according to an embodiment. A method of fabricating the display device **1001** according to an embodiment will be described below.

Referring to FIG. **13**, each growth substrate corresponding to the red semiconductor light emitting device (R) **1100**, green semiconductor light emitting device (G) **1100**, and blue semiconductor light emitting device (B) **1100** is prepared.

The growth substrate **1101** (wafer) may be formed with a material having light transmitting properties, for example, including any one of sapphire (Al_2O_3), GaN, ZnO, and AlO, but may not be necessarily limited to this. Furthermore, the growth substrate **1101** may be formed of a material suitable to semiconductor material growth, namely, carrier wafer. Furthermore, the growth substrate **1101** may be formed of a material with excellent thermal conductivity characteristics, and may include a conductive substrate or insulating substrate

to use an SiC substrate having a thermal conductivity greater than that of sapphire (Al_2O_3) substrate or any one of Si, GaAs, GaP, InP, and Ga_2O_3 .

A buffer layer **1102** for alleviating a lattice mismatch between the growth substrate **1101** and first conductive semiconductor layer **1110** and allowing the semiconductor layer to be easily grown may be located on the growth substrate **1101**. The buffer layer **1102** may be formed in a low temperature atmosphere, and made of a material capable of alleviating a lattice constant difference between the semiconductor layer and growth substrate **1101**. For example, the buffer layer **1102** may include a material such as GaN, InN, AlN, AlInN, InGaN, AlGaN, and InAlGaN, but may not be necessarily limited to this.

The buffer layer **1102** may be grown as a single crystal on the growth substrate **1101**, and the buffer layer **1102** grown as a single crystal may enhance the crystallinity of the first conductive semiconductor layer **1110** being grown on the buffer layer **1102**.

A light emitting structure including the second conductive semiconductor layer **1130**, the active layer **1120** located on the second conductive semiconductor layer **1130**, and the first conductive semiconductor layer **1110** located on the active layer **1120** is grown on the buffer layer **1102**. Of course, the constituent material of the light emitting structure of the red semiconductor light emitting device (R) **1100**, green semiconductor light emitting device (G) **1100** and blue semiconductor light emitting device (B) **1100** is the same as described above, and separately grown.

A reflective layer **1163** is formed on the first conductive semiconductor layer **1110**.

Referring to FIG. **14**, the light emitting structure of the red semiconductor light emitting device (R) **1100**, green semiconductor light emitting device (G) **1100**, and blue semiconductor light emitting device (B) **1100** is partitioned for each semiconductor light emitting device **1100** in a chip unit. In other words, the first conductive semiconductor layer **1110**, active layer **1120** and second conductive semiconductor layer **1130** may be removed in a matrix form.

For a method of partitioning the semiconductor light emitting device **1100** into each chip unit, wet etching, dry etching or laser lift off (LLO) methods may be used, but the present disclosure may not be necessarily limited to this.

Furthermore, one region of the first conductive semiconductor layer **1110** and active layer **1120** is removed to expose one region of the second conductive semiconductor layer **1130**.

Then, the first electrode **1140** and second electrode **1150** are formed on an upper surface of the first conductive semiconductor layer **1110** and an upper surface of the exposed second conductive semiconductor layer **1130**.

The first electrode **1140** and second electrode **1150** may be formed with a deposition method such as sputtering or the like. However, the present disclosure may not be necessarily limited to this.

Referring to FIG. **15**, the red semiconductor light emitting device (R) **1100** in a region at which the blue semiconductor light emitting device (B) **1100** and green semiconductor light emitting device (G) **1100** are located is removed from the partitioned red semiconductor light emitting devices (R) **1100** in a chip unit in the light emitting structure of the red semiconductor light emitting device (R) **1100**.

The green semiconductor light emitting devices (G) **1100** and blue semiconductor light emitting devices (B) **1100** in a chip unit are adhered to a region from which the light emitting

structure of the red semiconductor light emitting device (R) 1100 is removed so as to correspond them to the pixel region (P).

Of course, an additional substrate (not shown) may be provided to individually adhere the grown red semiconductor light emitting device (R) 1100, green semiconductor light emitting device (G) 1100, and blue semiconductor light emitting device (B) 1100 to the foregoing substrate. However, the present disclosure may not be necessarily limited to this.

Referring to FIG. 16, the lower substrate 1010 disposed with the line electrode 1011 is provided at an upper portion thereof.

A conductive adhesive layer 1020 having adhesiveness, mobility and viscosity is disposed on the lower substrate 1010.

A set in which the semiconductor light emitting device 1100 and growth substrate 1101 are coupled to each other is prepared such that the first electrode 1140 and second electrode 1150 of the semiconductor light emitting device 1100 are directed toward the lower substrate 1010.

A set with the semiconductor light emitting device 1100 and growth substrate 1101 is aligned with the line electrode 1011, and then heat or catalyst is applied thereto while pressuring the conductive adhesive layer 1020.

The conductive adhesive layer 1020 has mobility due to heat, and the semiconductor light emitting device 1100, first electrode 1140 and second electrode 1150 are surrounded by the body 1021 of the conductive adhesive layer 1020, and the first electrode 1140 and second electrode 1150 are electrically connected to the line electrode 1011 by means of the conductors 1022.

Then, the conductive adhesive layer 1020 is cured during the process of dissipating heat.

Referring to FIG. 17, when the conductive adhesive layer 1020 is cured, the growth substrate 1101 and buffer layer 1102 are removed. For a method of removing the growth substrate 1101 and buffer layer 1102, wet etching, dry etching or laser lift off (LLO) methods may be used, but the present disclosure may not be necessarily limited to this.

Referring to FIG. 18, a protective substrate 1030 is bonded to a surface from which the growth substrate 1101 and buffer layer 1102 are removed (an upper surface of the second conductive semiconductor layer with reference to FIG. 17).

While the invention has been shown and described with respect to various embodiments of the present invention, it will be of course understood by those skilled in the art that various modifications may be made without departing from the gist of the invention as defined in the following claims, and it is to be noted that those modifications should not be understood individually from the technical concept and prospect of the present invention.

What is claimed is:

1. A display device, comprising:

a lower substrate;

a line electrode located at the lower substrate;

a plurality of semiconductor light emitting devices electrically connected to the line electrode and configured to generate light, the plurality of semiconductor light emitting devices including red, green and blue semiconductor light emitting devices that emit red, green and blue light, respectively, to form one pixel region, the plurality of semiconductor light emitting devices containing inorganic semiconductor materials; and

a conductive adhesive layer, the conductive adhesive layer comprising:

a body configured to combine the lower substrate with the semiconductor light emitting devices, and

conductors dispersed within the body to electrically connect the lower substrate to the semiconductor light emitting devices,

wherein the semiconductor light emitting devices comprise:

a first conductive semiconductor layer;

an active layer located on the first conductive semiconductor layer;

a second conductive semiconductor layer located on the active layer; and

a first electrode electrically connected to the first conductive semiconductor layer,

wherein a reflective layer is located on a lower surface of the first conductive semiconductor layer, and

wherein the first electrode is disposed at one region of the lower surface, and the reflective layer is disposed at another region of the lower surface.

2. The display device of claim 1, further comprising:

a second electrode electrically connected to the second conductive semiconductor layer,

wherein the first electrode is disposed on a lower surface of the first conductive semiconductor layer, and

wherein the second electrode is disposed on a lower surface of the second conductive semiconductor layer.

3. The display device of claim 2, wherein the body of the conductive adhesive layer surrounds the first electrode and the second electrode.

4. The display device of claim 3, wherein the first electrode and the second electrode are in contact with a portion of the conductors.

5. The display device of claim 1, wherein the reflective layer includes:

a first layer having a first refractive index, and

a second layer having a second refractive index which is different from the first refractive index.

6. The display device of claim 1, further comprising an electron blocking layer located between the active layer and the second conductive semiconductor layer, the electron blocking layer having a band gap energy greater than that of the active layer and the second conductive semiconductor layer.

7. The display device of claim 1, wherein the red semiconductor light emitting device has a composition formula of $(Al_xGa_{1-x})_{0.5}In_{0.5}P$.

8. The display device of claim 1, wherein the red semiconductor light emitting device has a composition formula of GaAsP.

9. The display device of claim 1, wherein the green semiconductor light emitting device has a composition formula of GaP.

10. The display device of claim 1, wherein the blue semiconductor light emitting device has a composition formula of $In_xAl_yGa_{1-x-y}N$ ($0 \leq x \leq 1$, $0 \leq y \leq 1$, $0 \leq x+y \leq 1$).

11. The display device of claim 1, wherein the body of the conductive adhesive layer is disposed to surround a lateral surface and a lower surface of the semiconductor light emitting devices.

12. The display device of claim 11, wherein the body of the conductive adhesive layer contains a non-transmitting synthetic resin that absorbs light generated from the semiconductor light emitting devices.

13. The display device of claim 1, wherein the body contains a material having adhesiveness.

14. The display device of claim 1, wherein the body has mobility and is cured in any one of a normal temperature, a high temperature and a catalyst atmosphere.

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15. The display device of claim 1, wherein the body contains a material that is black.

16. The display device of claim 1, wherein the line electrode is formed to be protruded in a direction of the semiconductor light emitting devices.

17. A display device, comprising:

a substrate;

an electrode located on the substrate;

a plurality of semiconductor light emitting devices electrically connected to the electrode and configured to generate light, the plurality of semiconductor light emitting devices containing inorganic semiconductor materials; and

a conductive adhesive layer interposed between the electrode and the substrate, the conductive adhesive layer comprising:

an adhesive body configured to fix the substrate to the semiconductor light emitting devices, and

conductors interspersed throughout the adhesive body to electrically connect the electrode to the semiconductor light emitting devices,

wherein the semiconductor light emitting devices comprise:

a first conductive semiconductor layer;

an active layer located on the first conductive semiconductor layer;

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a second conductive semiconductor layer located on the active layer; and

a first electrode electrically connected to the first conductive semiconductor layer,

wherein a reflective layer is located on a lower surface of the first conductive semiconductor layer, and

wherein the first electrode is disposed at one region of the lower surface, and the reflective layer is disposed at another region of the lower surface.

18. The display device of claim 17, wherein the semiconductor light emitting devices face the electrode without touching the electrode, and

wherein the conductors of the conductive adhesive layer are interposed between the electrode and respective ones of the semiconductor light emitting devices to provide an electrical connection between the electrode and respective ones of the semiconductor light emitting devices.

19. The display device of claim 17, wherein the adhesive body of the conductive adhesive layer is located between adjacent ones of the semiconductor light emitting devices and surrounds lateral surfaces of the semiconductor light emitting devices.

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